



## DLP7000 DLP® 0.7 XGA 2x LVDS Type A DMD

### 1 Features

- 0.7-Inch Diagonal Micromirror Array
  - 1024 x 768 Array of Aluminum, Micrometer-Sized Mirrors
  - 13.68  $\mu\text{m}$  Micromirror Pitch
  - $\pm 12^\circ$  Micromirror Tilt Angle (Relative to Flat State)
  - Designed for Corner Illumination
- Designed for Use With Broadband Visible Light (400 to 700 nm):
  - Window Transmission 97% (Single Pass, Through Two Window Surfaces)
  - Micromirror Reflectivity 88%
  - Array Diffraction Efficiency 86%
  - Array Fill Factor 92%
- Two 16-Bit, Low Voltage Differential Signaling (LVDS) Double Data Rate (DDR) Input Data Buses
- Up to 400 MHz Input Data Clock Rate
- 40.64-mm by 31.75-mm by 6.0-mm Package Footprint
- Hermetic Package

### 2 Applications

- Industrial
  - Digital Imaging Lithography
  - Laser Marking
  - LCD and OLED Repair
  - Computer-to-Plate Printers
  - SLA 3D Printers
  - 3D Scanners for Machine Vision and Factory Automation
  - Flat Panel Lithography
- Medical
  - Phototherapy Devices
  - Ophthalmology
  - Direct Manufacturing
  - Hyperspectral Imaging
  - 3D Biometrics
  - Confocal Microscopes
- Display
  - 3D Imaging Microscopes
  - Adaptive Illumination
  - Augmented Reality and Information Overlay

### 3 Description

The DLP7000 XGA Chipset is part of the DLP® Discovery™ 4100 platform, which enables high resolution and high performance spatial light modulation. The DLP7000 is the digital micromirror device (DMD) fundamental to the 0.7 XGA chipset, and currently supports the fastest pattern rates in the DLP catalog portfolio. The DLP Discovery 4100 platform also provides the highest level of individual micromirror control with the option for random row addressing. Combined with a hermetic package, the unique capability and value offered by DLP7000 makes it well suited to support a wide variety of industrial, medical, and advanced display applications.

In addition to the DLP7000 DMD, the 0.7 XGA Chipset includes these components:

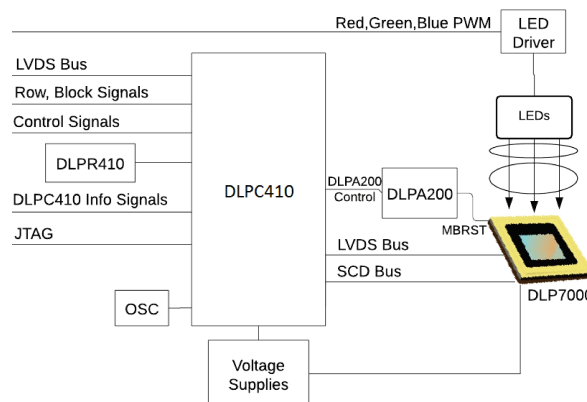
- Dedicated DLPC410 controller for high speed pattern rates of >32000 Hz (1-bit binary) and >1900 Hz (8-bit gray)
- One unit DLPR410 (DLP Discovery 4100 Configuration PROM)
- One unit DLPA200 (DMD Micromirror Driver)

#### Device Information<sup>(1)</sup>

PART NUMBER	PACKAGE	BODY SIZE (NOM)
DLP7000	LCCC (203)	40.64 mm x 31.75 mm

(1) For all available packages, see the orderable addendum at the end of the data sheet.

#### Typical Application Schematic



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## 4 Revision History

NOTE: Page numbers for previous revisions may differ from page numbers in the current version.

Changes from Revision C (April 2014) to Revision D	Page
• Updated <a href="#">Figure 21</a>	44
• Updated <a href="#">Figure 22</a>	44

Changes from Revision B (June 2013) to Revision C	Page
• Added <i>Pin Configuration and Functions</i> section, <i>ESD Rating</i> table, <i>Feature Description</i> section, <i>Device Functional Modes</i> , <i>Application and Implementation</i> section, <i>Power Supply Recommendations</i> section, <i>Layout</i> section, <i>Device and Documentation Support</i> section, and <i>Mechanical, Packaging, and Orderable Information</i> section	1
• Deleted / DLPR4101 Enhanced PROM from Chipset List	1
• Corrected VCC2 max to 8 V	11
• Added array temperature vs duty cycle graph	13
• Replaced serial communications bus timing parameters	17
• Converted interface loads to Newtons	18
• Grayed out LVDS buses that are unused on DLP7000	26
• Added micromirror landed duty cycle section	35
• Changed to DLP7000	38
• Deleted / DLPR4101 Enhanced PROM from Related Documentation	45

<b>Changes from Revision A (September 2012) to Revision B</b>	<b>Page</b>
• Added / DLPR4101 Enhanced PROM to DLPR410 in Chipset List.....	<a href="#">1</a>
• Changed pin number of DCLK_AN From: D19 To: B22 .....	<a href="#">8</a>
• Changed pin number of DCLK_AP From: E19 To: B24 .....	<a href="#">8</a>
• Changed pin number of DCLK_BN From: M19 To: AB22 .....	<a href="#">8</a>
• Changed pin number of DCLK_BP From: N19 To: AB24 .....	<a href="#">8</a>
• Added / DLPR4101 Enhanced PROM to DLPR410 in Related Documentation .....	<a href="#">45</a>
 <b>Changes from Original (August 2012) to Revision A</b>	 <b>Page</b>
• Changed the device From: Product Preview To: Production .....	<a href="#">1</a>

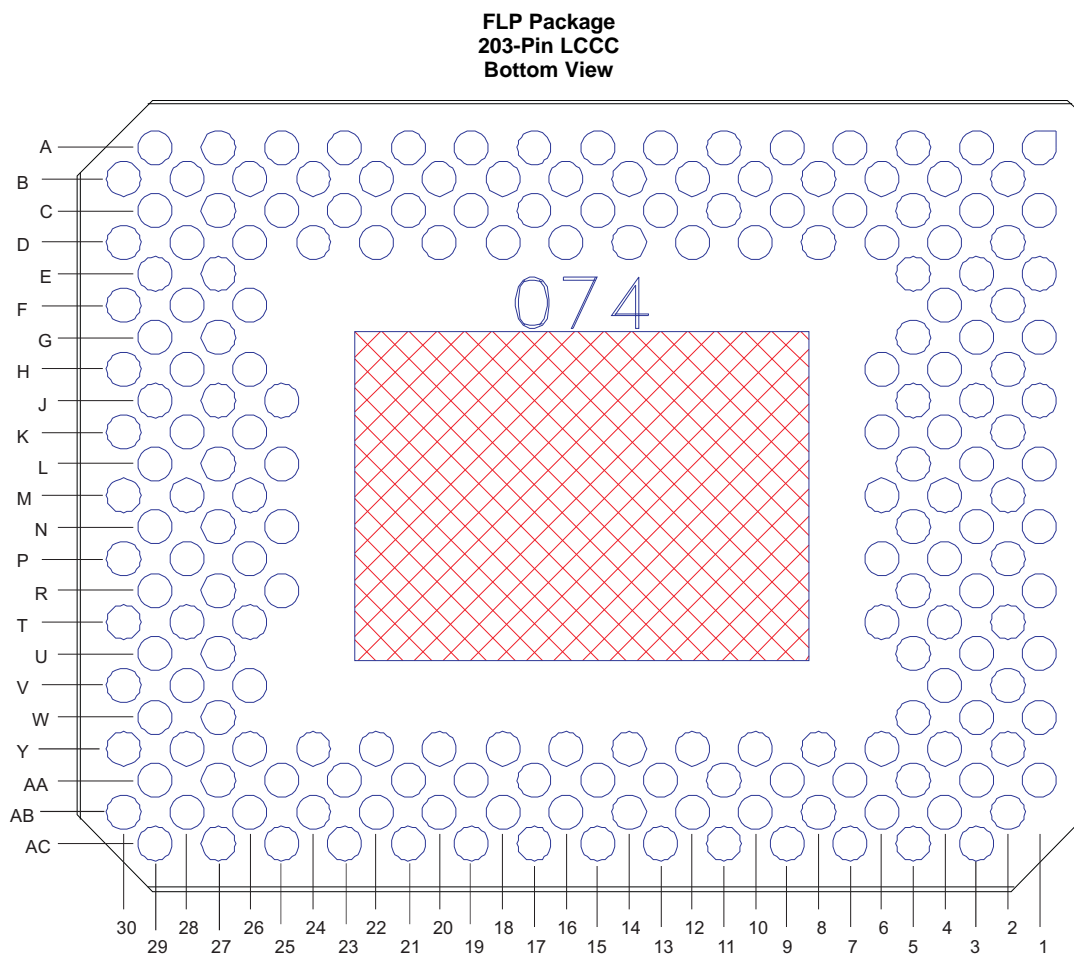
## 5 Description (continued)

Reliable function and operation of the DLP7000 requires that it be used in conjunction with the other components of the chipset. A dedicated chipset provides developers easier access to the DMD as well as high speed, independent micromirror control.

DLP7000 is a digitally controlled micro-electromechanical system (MEMS) spatial light modulator (SLM). When coupled to an appropriate optical system, the DLP7000 can be used to modulate the amplitude, direction, and/or phase of incoming light.

Electrically, the DLP7000 consists of a two-dimensional array of 1-bit CMOS memory cells, organized in a grid of 1024 memory cell columns by 768 memory cell rows. The CMOS memory array is addressed on a row-by-row basis, over two 16-bit Low Voltage Differential Signaling (LVDS) double data rate (DDR) buses. Addressing is handled via a serial control bus. The specific CMOS memory access protocol is handled by the DLPC410 digital controller.

## 6 Pin Configuration and Functions



### Pin Functions

PIN <sup>(1)</sup>		TYPE (I/O/P)	SIGNAL	DATA RATE <sup>(2)</sup>	INTERNAL TERM <sup>(3)</sup>	CLOCK	DESCRIPTION	TRACE
NAME	NO.							
DATA INPUT								
D_AN(0)	B10	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A	Input data bus A (2x LVDS)	368.72
D_AN(1)	A13	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		424.61
D_AN(2)	D16	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		433.87
D_AN(3)	C17	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		391.39
D_AN(4)	B18	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		438.57
D_AN(5)	A17	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		391.13
D_AN(6)	A25	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		563.26
D_AN(7)	D22	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		411.62
D_AN(8)	C29	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		595.11
D_AN(9)	D28	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		543.07
D_AN(10)	E27	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		455.98
D_AN(11)	F26	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		359.5
D_AN(12)	G29	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		542.67
D_AN(13)	H28	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		551.51
D_AN(14)	J27	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		528.04
D_AN(15)	K26	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		484.38
D_AP(0)	B12	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		366.99
D_AP(1)	A11	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A		417.47

(1) The following power supplies are required to operate the DMD: VCC, VCC1, VCC2. VSS must also be connected.

(2) DDR = Double Data Rate. SDR = Single Data Rate. Refer to the [LVDS Timing Requirements](#) for specifications and relationships.

(3) Refer to [Electrical Characteristics](#) for differential termination specification.

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## Pin Functions (continued)

PIN <sup>(1)</sup>		TYPE (I/O/P)	SIGNAL	DATA RATE <sup>(2)</sup>	INTERNAL TERM <sup>(3)</sup>	CLOCK	DESCRIPTION	TRACE
NAME	NO.							
D_AP(2)	D14	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A	Input data bus A (2x LVDS)	434.89
D_AP(3)	C15	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		394.67
D_AP(4)	B16	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		437.3
D_AP(5)	A19	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		389.01
D_AP(6)	A23	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		562.92
D_AP(7)	D20	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		410.34
D_AP(8)	A29	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		594.61
D_AP(9)	B28	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		539.88
D_AP(10)	C27	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		456.78
D_AP(11)	D26	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		360.68
D_AP(12)	F30	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		543.97
D_AP(13)	H30	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		570.85
D_AP(14)	J29	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		527.18
D_AP(15)	K28	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_A		481.02
D_BN(0)	AB10	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		368.72
D_BN(1)	AC13	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		424.61
D_BN(2)	Y16	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		433.87
D_BN(3)	AA17	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		391.39
D_BN(4)	AB18	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		438.57

**Pin Functions (continued)**

PIN <sup>(1)</sup>		TYPE (I/O/P)	SIGNAL	DATA RATE <sup>(2)</sup>	INTERNAL TERM <sup>(3)</sup>	CLOCK	DESCRIPTION	TRACE
NAME	NO.							
D_BN(5)	AC17	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		391.13
D_BN(6)	AC25	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		563.26
D_BN(7)	Y22	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		411.62
D_BN(8)	AA29	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		595.11
D_BN(9)	Y28	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		543.07
D_BN(10)	W27	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		455.98
D_BN(11)	V26	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		360.94
D_BN(12)	T30	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		575.85
D_BN(13)	R29	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B	Input data bus A - continued (2x LVDS)	519.37
D_BN(14)	R27	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		532.59
D_BN(15)	N27	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		441.14
D_BP(0)	AB12	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B	Input data bus B (2x LVDS) Input data bus B (2x LVDS)	366.99
D_BP(1)	AC11	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		417.47
D_BP(2)	Y14	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		434.89
D_BP(3)	AA15	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		394.67
D_BP(4)	AB16	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		437.3
D_BP(5)	AC19	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		389.01
D_BP(6)	AC23	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		562.92
D_BP(7)	Y20	Input	LVC MOS	DDR	Differential Terminated - 100 Ω	DCLK_B		410.34

**Pin Functions (continued)**

PIN <sup>(1)</sup>		TYPE (I/O/P)	SIGNAL	DATA RATE <sup>(2)</sup>	INTERNAL TERM <sup>(3)</sup>	CLOCK	DESCRIPTION	TRACE
NAME	NO.							
D_BP(8)	AC29	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		594.61
D_BP(9)	AB28	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		539.88
D_BP(10)	AA27	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		456.78
D_BP(11)	Y26	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		360.68
D_BP(12)	U29	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		578.46
D_BP(13)	T28	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B	Input data bus B (2x LVDS)	509.74
D_BP(14)	P28	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		534.59
D_BP(15)	P26	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B		440
DATA CLOCK								
DCLK_AN	B22	Input	LVCMOS	–	Differential Terminated - 100 Ω	–		
DCLK_AP	B24	Input	LVCMOS	–	Differential Terminated - 100 Ω	–		
DCLK_BN	AB22	Input	LVCMOS	–	Differential Terminated - 100 Ω	–		
DCLK_BP	AB24	Input	LVCMOS	–	Differential Terminated - 100 Ω	–		
DATA CONTROL INPUTS								
SCTRL_AN	C21	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A	Serial control for data bus A (2x LVDS)	477.07
SCTRL_AP	C23	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_A	477.14	
SCTRL_BN	AA21	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B	Serial control for data bus B (2x LVDS)	477.07
SCTRL_BP	AA23	Input	LVCMOS	DDR	Differential Terminated - 100 Ω	DCLK_B	477.14	
SERIAL COMMUNICATION AND CONFIGURATION								
SCPCLK	E3	Input	LVCMOS	–	Pull-down	–	Serial port clock	379.29
SCPDO	B2	Output	LVCMOS	–	–	SCPCLK	Serial port output	480.91
SCPDI	F4	Input	LVCMOS	–	Pull-down	SCPCLK	Serial port input	323.56
SCPENZ	D4	Input	LVCMOS	–	Pull-down	SCPCLK	Serial port enable	326.99
PWRDNZ	C3	Input	LVCMOS	–	Pull-down	–	Device Reset	406.28



**Pin Functions (continued)**

PIN <sup>(1)</sup>		TYPE (I/O/P)	SIGNAL	DATA RATE <sup>(2)</sup>	INTERNAL TERM <sup>(3)</sup>	CLOCK	DESCRIPTION	TRACE
NAME	NO.							
MODE_A	D8	Input	LVC MOS	—	Pull-down	—	Data bandwidth mode select	396.05
MODE_B	C11	Input	LVC MOS	—	Pull-down	—		208.86
MICROMIRROR BIAS CLOCKING PULSE								
MBRST(0)	P2	Input	Analog	—	—	—		
MBRST(1)	AB4	Input	Analog	—	—	—		
MBRST(2)	AA7	Input	Analog	—	—	—		
MBRST(3)	N3	Input	Analog	—	—	—		
MBRST(4)	M4	Input	Analog	—	—	—		
MBRST(5)	AB6	Input	Analog	—	—	—		
MBRST(6)	AA5	Input	Analog	—	—	—		
MBRST(7)	L3	Input	Analog	—	—	—	Micromirror Bias Clocking Pulse "MBRST" signals "clock" micromirrors into state of LVC MOS memory cell associated with each mirror.	
MBRST(8)	Y6	Input	Analog	—	—	—		
MBRST(9)	K4	Input	Analog	—	—	—		
MBRST(10)	L5	Input	Analog	—	—	—		
MBRST(11)	AC5	Input	Analog	—	—	—		
MBRST(12)	Y8	Input	Analog	—	—	—		
MBRST(13)	J5	Input	Analog	—	—	—		
MBRST(14)	K6	Input	Analog	—	—	—		
MBRST(15)	AC7	Input	Analog	—	—	—		
POWER								
V <sub>CC</sub>	A7, A15, C1, E1, U1, W1, AB2, AC9, AC15	Power	Analog	—	—	—	Power for LVC MOS Logic	—
V <sub>CC1</sub>	A21, A27, D30, M30, Y30, AC21, AC27	Power	Analog	—	—	—	Power supply for LVDS Interface	—
V <sub>CC2</sub>	G1, J1, L1, N1, R1	Power	Analog	—	—	—	Power for High Voltage CMOS Logic	—

**DLP7000**

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**Pin Functions (continued)**

PIN <sup>(1)</sup>		TYPE (I/O/P)	SIGNAL	DATA RATE <sup>(2)</sup>	INTERNAL TERM <sup>(3)</sup>	CLOCK	DESCRIPTION	TRACE
NAME	NO.							
V <sub>SS</sub>	A1, A3, A5, A9, B4, B8, B14, B20, B26, B30, C7, C13, C19, C25, D6, D12, D18, D24, E29, F2, F28, G3, G27, H2, H4, H26, J3, J25, K2, K30, L25, L27, L29, M2, M6, M26, M28, N5, N25, N29, P4, P30, R3, R5, R25, T2, T26, U27, V28, V30, W5, W29, Y4, Y12, Y18, Y24, AA3, AA9, AA13, AA19, AA25, AB8, AB14, AB20, AB26, AB30	Power	Analog	–	–	–	Common return for all power inputs	–
<b>RESERVED SIGNALS (NOT FOR USE IN SYSTEM)</b>								
RESERVED _AA1	AA1	Input	LVC MOS	–	Pull-down	–	Pins should be connected to V <sub>SS</sub>	–
RESERVED _B6	B6	Input	LVC MOS	–	Pull-down	–	–	–
RESERVED _T4	T4	Input	LVC MOS	–	Pull-down	–	–	–
RESERVED _U5	U5	Input	LVC MOS	–	Pull-down	–	–	–
NO_CONN ECT	AA11, AC3, C5, C9, D10, D2, E5, G5, H6, P6, T6, U3, V2, V4, W3, Y10, Y2	–	–	–	–	–	Do not connect	–

## 7 Specifications

### 7.1 Absolute Maximum Ratings

over operating free-air temperature range (unless otherwise noted)<sup>(1)</sup>

		MIN	MAX	UNIT
<b>ELECTRICAL</b>				
V <sub>CC</sub>	Voltage applied to V <sub>CC</sub> <sup>(2) (3)</sup>	–0.5	4	V
V <sub>CCI</sub>	Voltage applied to V <sub>CCI</sub> <sup>(2) (3)</sup>	–0.5	4	V
V <sub>CC2</sub>	Voltage applied to V <sub>VCC2</sub> <sup>(2) (3) (4)</sup>	–0.5	8	V
V <sub>MBRST</sub>	Micromirror Clocking Pulse Waveform Voltage applied to MBRST[15:0] Input Pins (supplied by DLPA200)	–28	28	V
V <sub>CC</sub> – V <sub>CCI</sub>	Supply voltage delta (absolute value) <sup>(4)</sup>		0.3	V
	Voltage applied to all other input pins <sup>(2)</sup>	–0.5	V <sub>CC</sub> + 0.3	V
V <sub>ID</sub>	Maximum differential voltage, Damage can occur to internal termination resistor if exceeded, See <a href="#">Figure 3</a>		700	mV
I <sub>OH</sub>	Current required from a high-level output V <sub>OH</sub> = 2.4 V		–20	mA
I <sub>OL</sub>	Current required from a low-level output V <sub>OL</sub> = 0.4 V		15	mA
<b>ENVIRONMENTAL</b>				
T <sub>C</sub>	Case temperature: operational <sup>(5)</sup>	10	65	°C
	Case temperature: non-operational <sup>(5)</sup>	–40	80	°C
T <sub>GRADIENT</sub>	Device temperature gradient - operational <sup>(6)</sup>		10	°C
	Operating relative humidity (non-condensing)	0	95	%RH

- (1) Stresses beyond those listed under [Absolute Maximum Ratings](#) may cause permanent damage to the device. These are stress ratings only, which do not imply functional operation of the device at these or any other conditions beyond those indicated under [Recommended Operating Conditions](#). Exposure to absolute-maximum-rated conditions for extended periods may affect device reliability.
- (2) All voltages referenced to V<sub>SS</sub> (ground).
- (3) V<sub>OFFSET</sub> supply transients must fall within specified max voltages.
- (4) To prevent excess current, the supply voltage delta |V<sub>CC</sub> – V<sub>CCI</sub>| must be less than specified limit.
- (5) DMD Temperature is the worst-case of any test point shown in [Figure 18](#), or the active array as calculated by the [Micromirror Array Temperature Calculation](#).
- (6) As measured between any two points on the exterior of the package, or as predicted between any two points inside the micromirror array cavity. Refer to [Thermal Information](#) and [Micromirror Array Temperature Calculation](#).

### 7.2 Storage Conditions

applicable before the DMD is installed in the final product

		MIN	MAX	UNIT
T <sub>stg</sub>	Storage temperature	–40	80	°C
	Storage humidity, non-condensing	0	95	%RH

### 7.3 ESD Ratings

				VALUE	UNIT
V <sub>(ESD)</sub>	Electrostatic discharge	Human-body model (HBM), per ANSI/ESDA/JEDEC JS-001 <sup>(1)</sup>	All pins except MBRST[15:0]	±2000	V
			Pins MBRST[15:0]	±250	

- (1) JEDEC document JEP155 states that 500-V HBM allows safe manufacturing with a standard ESD control process.

## 7.4 Recommended Operating Conditions

over operating free-air temperature range (unless otherwise noted)

		MIN	NOM	MAX	UNIT
<b>SUPPLY VOLTAGES<sup>(1) (2)</sup></b>					
V <sub>CC</sub>	Supply voltage for LVCMOS core logic	3	3.3	3.6	V
V <sub>CCI</sub>	Supply voltage for LVDS receivers	3	3.3	3.6	V
V <sub>CC2</sub>	Mirror electrode and HVCMOS supply voltage <sup>(3)</sup>	7.25	7.5	7.75	V
V <sub>MBRST</sub>	Clocking Pulse Waveform Voltage applied to MBRST[29:0] Input Pins (supplied by DLPA200s)	–27		26.5	V
V <sub>CC</sub> – V <sub>CCI</sub>	Supply voltage delta (absolute value) <sup>(4)</sup>			0.3	V
<b>ENVIRONMENTAL <sup>(5)</sup> For Illumination Source between 420 and 700 nm</b>					
T <sub>C</sub>	Operating Case Temperature <sup>(6)</sup> : Thermal Test Points 1 and 2 <sup>(7)</sup>	10	25-45	65 <sup>(7)</sup>	°C
	Operating Case Temperature <sup>(6)</sup> : Thermal Test Point 3 and Array <sup>(7)</sup>	10	25-45	65 <sup>(7)</sup>	°C
T <sub>GRADIENT</sub>	Device temperature gradient – operational <sup>(8)</sup>			10	°C
	Operating relative humidity (non-condensing)	0		95	%RH
ILL <sub>VIS</sub>	Illumination			Thermally Limited <sup>(9)</sup>	W/cm <sup>2</sup>
<b>ENVIRONMENTAL <sup>(5)</sup> For Illumination Source between 400 and 420 nm</b>					
T <sub>C</sub>	Operating Case Temperature <sup>(6)</sup> : Thermal Test Points 1 and 2 <sup>(7)</sup>	10	25-45	65 <sup>(7)</sup>	°C
	Operating Case Temperature <sup>(6)</sup> : Thermal Test Point 3 and Array <sup>(7)</sup>	10	25-45	65 <sup>(7)</sup>	°C
T <sub>GRADIENT</sub>	Device temperature gradient – operational <sup>(8)</sup>			10	°C
	Operating relative humidity (non-condensing)	0		95	%RH
ILL <sub>VIS</sub>	Illumination			2.5	W/cm <sup>2</sup>
<b>ENVIRONMENTAL <sup>(5)</sup> For Illumination Source &lt;400 and &gt;700 nm</b>					
T <sub>C</sub>	Operating Case Temperature <sup>(6)</sup> : Thermal Test Points 1 and 2 <sup>(7)</sup>	10	25-45	65 <sup>(7)</sup>	°C
	Operating Case Temperature <sup>(6)</sup> : Thermal Test Point 3 and Array <sup>(7)</sup>	10	25-45	65 <sup>(7)</sup>	°C
T <sub>GRADIENT</sub>	Device temperature gradient – operational <sup>(8)</sup>			10	°C
	Operating relative humidity (non-condensing)	0		95	%RH
ILL <sub>UV</sub>	Illumination, wavelength <400 nm			0.68	mW/cm <sup>2</sup>
ILL <sub>IR</sub>	Illumination, wavelength >700 nm			10	mW/cm <sup>2</sup>

(1) Supply voltages V<sub>CC</sub>, V<sub>CCI</sub>, V<sub>OFFSET</sub>, V<sub>BIAS</sub>, and V<sub>RESET</sub> are all required for proper DMD operation. V<sub>SS</sub> must also be connected.

(2) All voltages are referenced to common ground V<sub>SS</sub>.

(3) Voltages V<sub>CC</sub>, V<sub>CCI</sub>, and V<sub>CC2</sub>, are required for proper DMD operation.

(4) To prevent excess current, the supply voltage delta |V<sub>CCI</sub> – V<sub>CC</sub>| must be less than specified limit.

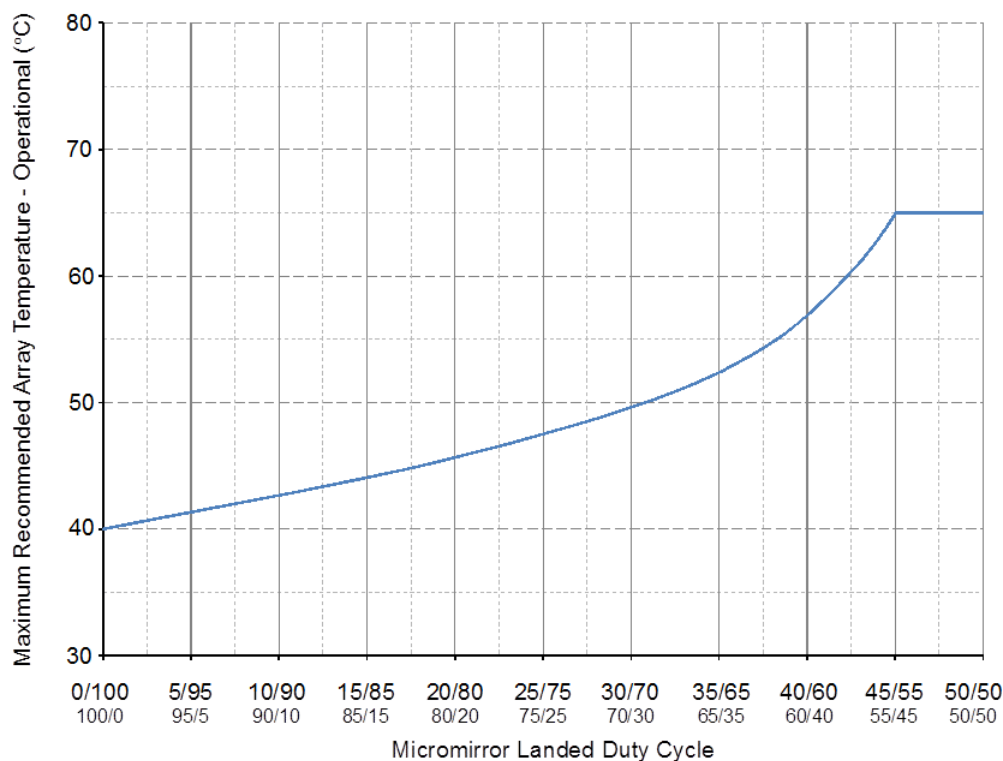
(5) Optimal, long-term performance and optical efficiency of the digital micromirror device (DMD) can be affected by various application parameters, including illumination spectrum, illumination power density, micromirror landed duty-cycle (Refer to [Figure 1](#)), ambient temperature (storage and operating), DMD temperature, ambient humidity (storage and operating), and power on or off duty cycle. TI recommends that application-specific effects be considered as early as possible in the design cycle.

(6) In some applications, the total DMD heat load can be dominated by the amount of incident light energy absorbed. See the [Thermal Information](#) for further details.

(7) See the [Thermal Information](#) and the [Micromirror Array Temperature Calculation](#) for Thermal Test Point Locations, Package Thermal Resistance, and Device Temperature Calculation.

(8) As measured between any two points on the exterior of the package, or as predicted between any two points inside the micromirror array cavity. Refer to [Thermal Information](#) and [Micromirror Array Temperature Calculation](#).

(9) Refer to [Thermal Information](#) and [Micromirror Array Temperature Calculation](#).



**Figure 1. Max Recommended DMD Temperature – Derating Curve**

## 7.5 Thermal Information

THERMAL METRIC <sup>(1)</sup>	DLP7000	UNIT
	FLP (LCCC)	
	203 PINS	
Active micromirror array resistance to TC2	0.90	°C/W

- (1) The DMD is designed to conduct absorbed and dissipated heat to the back of the package where it can be removed by an appropriate heat sink. The heat sink and cooling system must be capable of maintaining the package within the temperature range specified in the [Recommended Operating Conditions](#). The total heat load on the DMD is largely driven by the incident light absorbed by the active area; although other contributions include light energy absorbed by the window aperture and electrical power dissipation of the array. Optical systems should be designed to minimize the light energy falling outside the window clear aperture since any additional thermal load in this area can significantly degrade the reliability of the device.

## DLP7000

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### 7.6 Electrical Characteristics

over the range of recommended supply voltage and recommended case operating temperature (unless otherwise noted).

PARAMETERS		TEST CONDITIONS	MIN	NOM	MAX	UNIT
V <sub>OH</sub>	High-level output voltage <sup>(1)</sup> , See <a href="#">Figure 11</a>	V <sub>CC</sub> = 3.0 V, I <sub>OH</sub> = –20 mA	2.4			V
V <sub>OL</sub>	Low-level output voltage <sup>(1)</sup> , See <a href="#">Figure 11</a>	V <sub>CC</sub> = 3.6 V, I <sub>OH</sub> = 15 mA			0.4	V
V <sub>MBRST</sub>	Clocking Pulse Waveform applied to MBRST[29:0] Input Pins (supplied by DLPA200)		–27		26.5	V
I <sub>OZ</sub>	High impedance output current <sup>(1)</sup>	V <sub>CC</sub> = 3.6 V			10	μA
I <sub>OH</sub>	High-level output current <sup>(1)</sup>	V <sub>OH</sub> = 2.4 V, V <sub>CC</sub> ≥ 3 V			–20	mA
		V <sub>OH</sub> = 1.7 V, V <sub>CC</sub> ≥ 2.25 V			–15	
I <sub>OL</sub>	Low-level output current <sup>(1)</sup>	V <sub>OL</sub> = 0.4 V, V <sub>CC</sub> ≥ 3 V			15	mA
		V <sub>OL</sub> = 0.4 V, V <sub>CC</sub> ≥ 2.25 V			14	
V <sub>IH</sub>	High-level input voltage <sup>(1)</sup>		1.7		V <sub>CC</sub> + .3	V
V <sub>IL</sub>	Low-level input voltage <sup>(1)</sup>		–0.3		0.7	V
I <sub>IL</sub>	Low-level input current <sup>(1)</sup>	V <sub>CC</sub> = 3.6 V, V <sub>I</sub> = 0 V			–60	μA
I <sub>IH</sub>	High-level input current <sup>(1)</sup>	V <sub>CC</sub> = 3.6 V, V <sub>I</sub> = V <sub>CC</sub>			200	μA
I <sub>CC</sub>	Current into V <sub>CC</sub> pin	V <sub>CC</sub> = 3.6 V,			1475	mA
I <sub>CCI</sub>	Current into V <sub>CCI</sub> pin <sup>(2)</sup>	V <sub>CCI</sub> = 3.6 V			450	mA
I <sub>CC2</sub>	Current into V <sub>CC2</sub> pin	V <sub>CC2</sub> = 8.75 V			25	mA
Z <sub>IN</sub>	Internal Differential Impedance		95		105	Ω
Z <sub>LINE</sub>	Line Differential Impedance (PWB, Trace)		90	100	110	Ω
C <sub>I</sub>	Input capacitance <sup>(1)</sup>	f = 1 MHz			10	pF
C <sub>O</sub>	Output capacitance <sup>(1)</sup>	f = 1 MHz			10	pF
C <sub>IM</sub>	Input capacitance for MBRST[29:0] pins	f = 1 MHz	220		270	pF

(1) Applies to LVCMOS pins only.

(2) Exceeding the maximum allowable absolute voltage difference between V<sub>CC</sub> and V<sub>CCI</sub> may result in excess current draw. See the [Absolute Maximum Ratings](#) for details.

## 7.7 LVDS Timing Requirements

over operating free-air temperature range (unless otherwise noted). See [Figure 2](#)

		MIN	NOM	MAX	UNIT
$f_{DCLK\_}$	DCLK_ <sub>*</sub> clock frequency {where * = [A, or B]}	200		400	MHz
$t_c$	Clock Cycle - DCLK_ <sub>*</sub>	2.5			ns
$t_w$	Pulse Width - DCLK_ <sub>*</sub>		1.25		ns
$t_s$	Setup Time - D_ <sub>*</sub> [15:0] and SCTRL_ <sub>*</sub> before DCLK_ <sub>*</sub>	.35			ns
$t_h$	Hold Time, D_ <sub>*</sub> [15:0] and SCTRL_ <sub>*</sub> after DCLK_ <sub>*</sub>	.35			ns
$t_{skew}$	Skew between bus A and B	–1.25		1.25	ns

## 7.8 LVDS Waveform Requirements

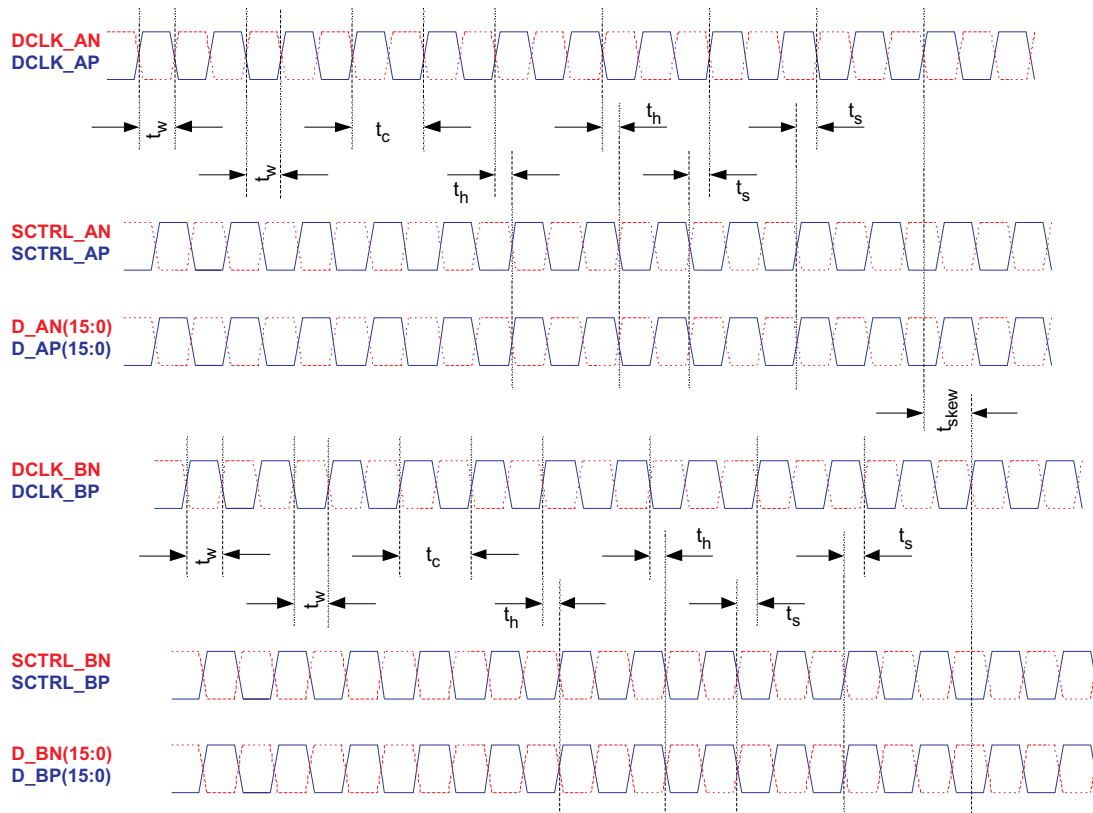
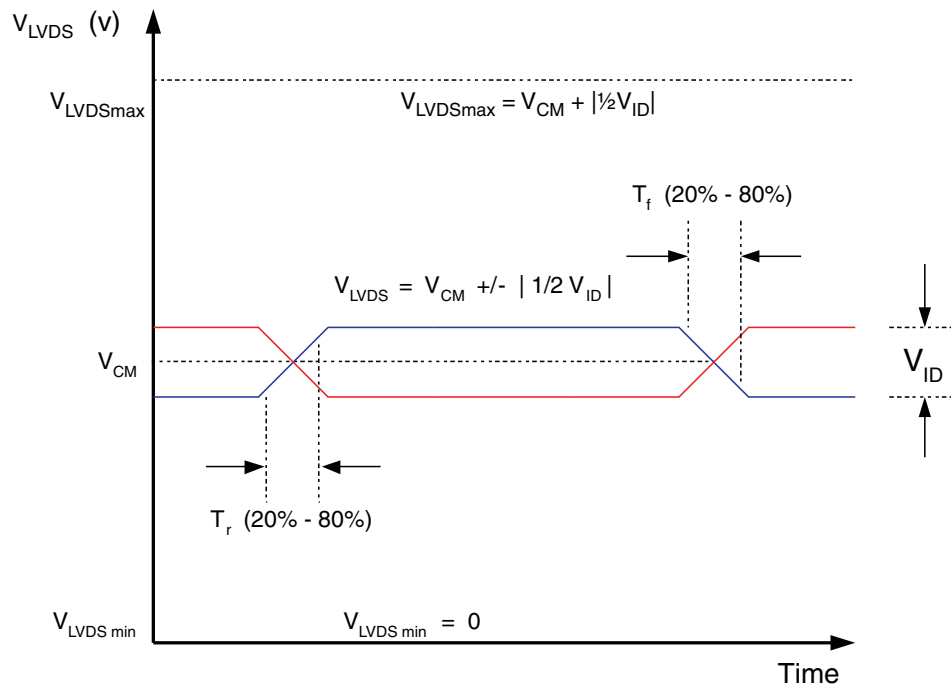
over operating free-air temperature range (unless otherwise noted). See [Figure 3](#)

		MIN	NOM	MAX	UNIT
$ V_{ID} $	Input Differential Voltage (absolute difference)	100	400	600	mV
$V_{CM}$	Common Mode Voltage		1200		mV
$V_{LVDS}$	LVDS Voltage	0		2000	mV
$t_r$	Rise Time (20% to 80%)	100		400	ps
$t_f$	Fall Time (80% to 20%)	100		400	ps

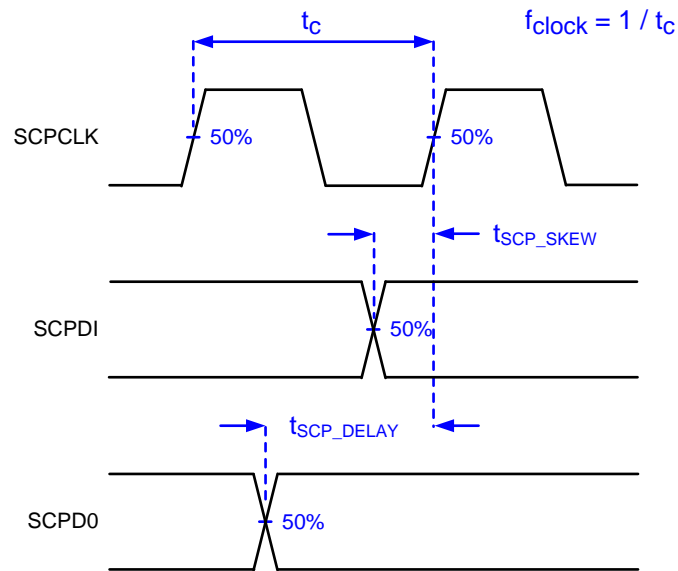
## 7.9 Serial Control Bus Timing Requirements

over operating free-air temperature range (unless otherwise noted). See [Figure 4](#) and [Figure 5](#)

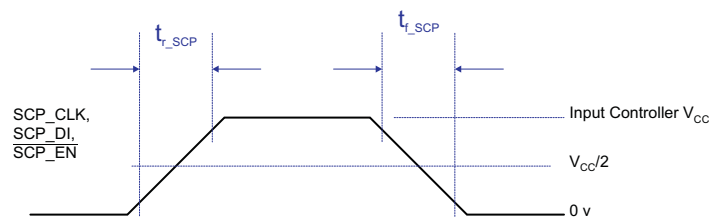
		MIN	NOM	MAX	UNIT
$f_{SCP\_CLK}$	SCP Clock Frequency	50		500	kHz
$t_{SCP\_SKEW}$	Time between valid SCP_DI and rising edge of SCP_CLK	–300		300	ns
$t_{SCP\_DELAY}$	Time between valid SCP_DO and rising edge of SCP_CLK			960	ns
$t_{SCP\_EN}$	Time between falling edge of SCP_EN and the first rising edge of SCP_CLK	30			ns
$t_{SCP}$	Rise time for SCP signals			200	ns
$t_{f\_SCP}$	Fall time for SCP signals			200	ns


**Figure 2. LVDS Timing Waveforms**

**Figure 3. LVDS Waveform Requirements**





**Figure 4. Serial Communications Bus Timing Parameters**



**Figure 5. Serial Communications Bus Waveform Requirements**

## 7.10 Systems Mounting Interface Loads

			MIN	NOM	MAX	UNIT
Maximum system mounting interface load to be applied to the:	Thermal Interface area	(See Figure 6)			111	N
	Electrical Interface area				423	N
	Datum "A" Interface area <sup>(1)</sup>				400	N

(1) Combined loads of the thermal and electrical interface areas in excess of Datum "A" load shall be evenly distributed outside the Datum "A" area ( $425 + 111 - \text{Datum "A"}$ ).

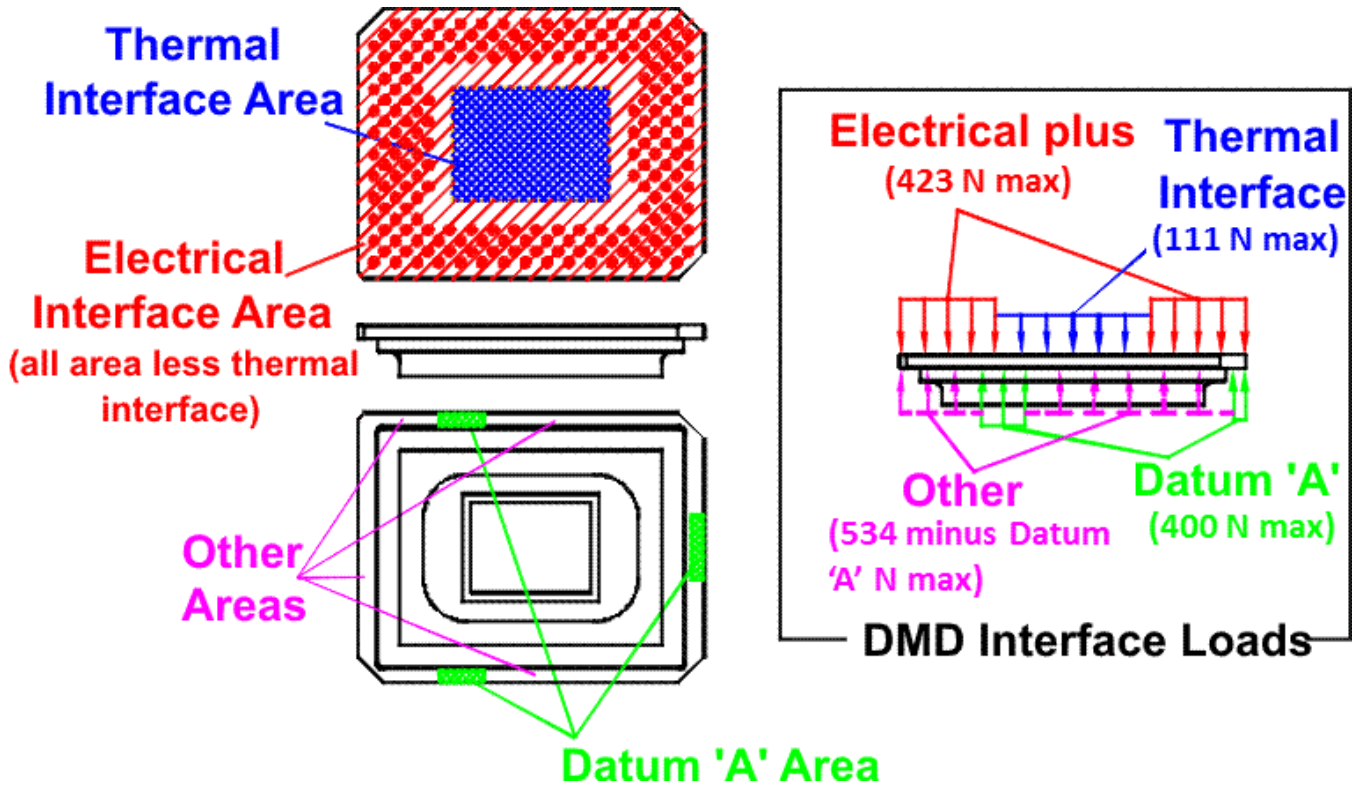
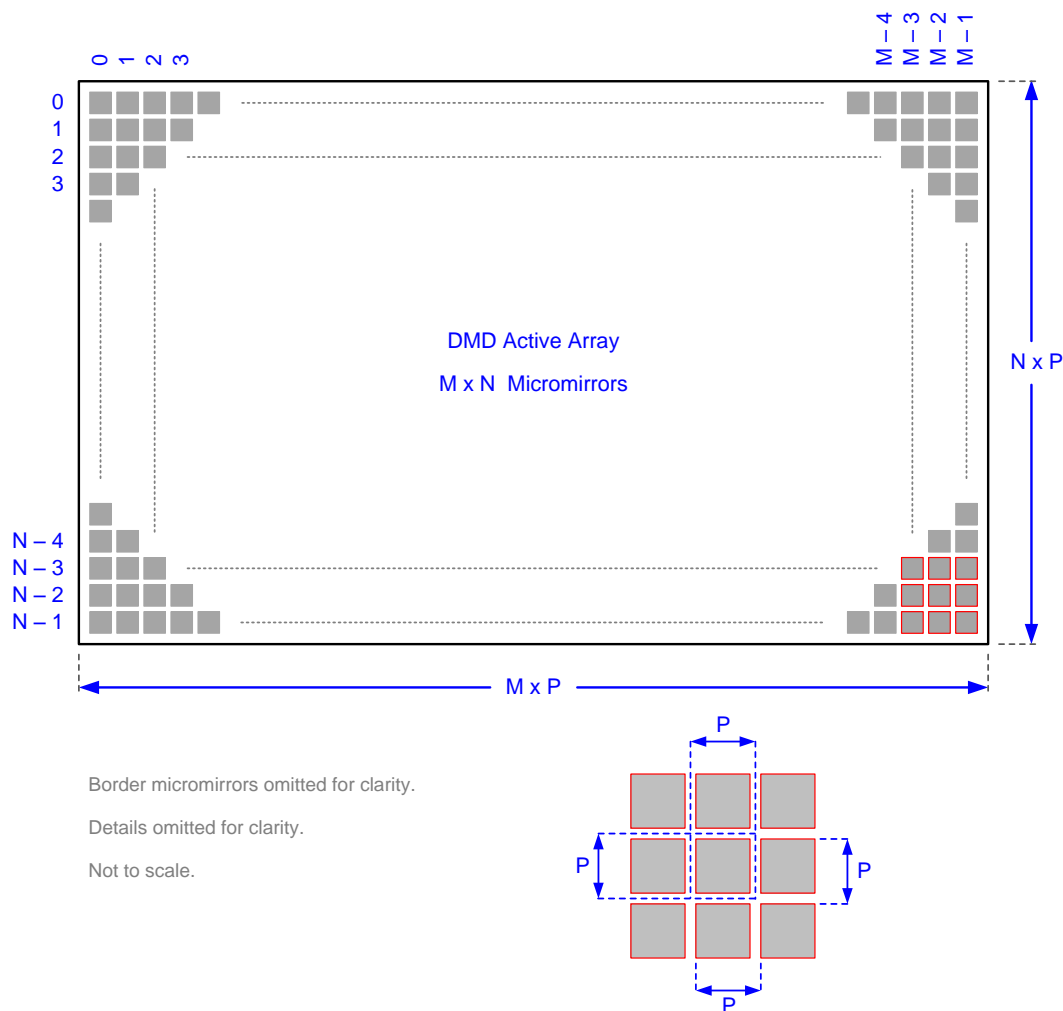


Figure 6. System Interface Loads

## 7.11 Micromirror Array Physical Characteristics

PARAMETER				VALUE	UNIT
M	Number of active columns		See Figure 7	1024	micromirrors
N	Number of active rows			768	micromirrors
P	Micromirror (pixel) pitch			13.68	μm
	Micromirror active array width	M × P		14.008	mm
	Micromirror active array height	N × P		10.506	mm
	Micromirror active border	Pond of micromirror (POM) <sup>(1)</sup>		10	micromirrors/side

- (1) The structure and qualities of the border around the active array includes a band of partially functional micromirrors called the POM. These micromirrors are structurally and/or electrically prevented from tilting toward the bright or ON state, but still require an electrical bias to tilt toward OFF.



Refer to *Micromirror Array Physical Characteristics* table for M, N, and P specifications.

**Figure 7. Micromirror Array Physical Characteristics**

## 7.12 Micromirror Array Optical Characteristics

TI assumes no responsibility for end-equipment optical performance. Achieving the desired end-equipment optical performance involves making trade-offs between numerous component and system design parameters.

PARAMETER	CONDITIONS	MIN	NOM	MAX	UNIT
a Micromirror tilt angle	DMD “parked” state <sup>(1) (2) (3)</sup> , See <a href="#">Figure 13</a>		0		degrees
	DMD “landed” state <sup>(1) (4) (5)</sup> See <a href="#">Figure 13</a>		12		
$\beta$ Micromirror tilt angle tolerance <sup>(1) (4) (6) (7) (8)</sup>	See <a href="#">Figure 13</a>	–1		1	degrees
Micromirror crossover time <sup>(9)</sup>			16	22	$\mu$ s
Micromirror switching time at 400 MHz with global reset <sup>(10)</sup>		43			$\mu$ s
Non operating micromirrors <sup>(11)</sup>	Non-adjacent micromirrors			10	micromirrors
	adjacent micromirrors			0	
Orientation of the micromirror axis-of-rotation <sup>(12)</sup>	See <a href="#">Figure 12</a>	44	45	46	degrees
Micromirror array optical efficiency <sup>(13) (14)</sup>	400 nm to 700 nm, with all micromirrors in the ON state		68%		

(1) Measured relative to the plane formed by the overall micromirror array.

(2) “Parking” the micromirror array returns all of the micromirrors to an essentially flat (0°) state (as measured relative to the plane formed by the overall micromirror array).

(3) When the micromirror array is “parked”, the tilt angle of each individual micromirror is uncontrolled.

(4) Additional variation exists between the micromirror array and the package datums, as shown in the [Mechanical, Packaging, and Orderable Information](#).

(5) When the micromirror array is “landed”, the tilt angle of each individual micromirror is dictated by the binary contents of the CMOS memory cell associated with each individual micromirror. A binary value of “1” will result in a micromirror “landing” in an nominal angular position of “+12°”. A binary value of 0 results in a micromirror “landing” in an nominal angular position of “-12°”.

(6) Represents the “landed” tilt angle variation relative to the Nominal “landed” tilt angle.

(7) Represents the variation that can occur between any two individual micromirrors, located on the same device or located on different devices.

(8) For some applications, it is critical to account for the micromirror tilt angle variation in the overall System Optical Design. With some System Optical Designs, the micromirror tilt angle variation within a device may result in perceivable non-uniformities in the light field reflected from the micromirror array. With some System Optical Designs, the micromirror tilt angle variation between devices may result in colorimetry variations and/or system contrast variations.

(9) Micromirror Cross Over time is primarily a function of the natural response time of the micromirrors.

(10) Micromirror switching is controlled and coordinated by the DLPC410 ([DLPS024](#)) and DLPA200 ([DLPS015](#)). Nominal Switching time depends on the system implementation and represents the time for the entire micromirror array to be refreshed.

(11) Non-operating micromirror is defined as a micromirror that is unable to transition nominally from the -12° position to +12° or vice versa.

(12) Measured relative to the package datums “B” and “C”, shown in [Mechanical, Packaging, and Orderable Information](#).

(13) The minimum or maximum DMD optical efficiency observed depends on numerous application-specific design variables, such as:

- Illumination wavelength, bandwidth/line-width, degree of coherence
- Illumination angle, plus angle tolerance
- Illumination and projection aperture size, and location in the system optical path
- Illumination overfill of the DMD micromirror array
- Aberrations present in the illumination source and/or path
- Aberrations present in the projection path

The specified nominal DMD optical efficiency is based on the following use conditions:

- Visible illumination (400 nm – 700 nm)
- Input illumination optical axis oriented at 24° relative to the window normal
- Projection optical axis oriented at 0° relative to the window normal
- f/3.0 illumination aperture
- f/2.4 projection aperture

Based on these use conditions, the nominal DMD optical efficiency results from the following four components:

- Micromirror array fill factor: nominally 92%
- Micromirror array diffraction efficiency: nominally 86%
- Micromirror surface reflectivity: nominally 88%

- Window transmission: nominally 97% (single pass, through two surface transitions)

(14) Does not account for the effect of micromirror switching duty cycle, which is application dependent. Micromirror switching duty cycle represents the percentage of time that the micromirror is actually reflecting light from the optical illumination path to the optical projection path. This duty cycle depends on the illumination aperture size, the projection aperture size, and the micromirror array update rate.

## 7.13 Window Characteristics

PARAMETER <sup>(1)</sup>	CONDITIONS	MIN	TYP	MAX	UNIT
Window material designation	Corning 7056				
Window refractive index	at wavelength 589 nm		1.487		
Window flatness <sup>(2)</sup>	Per 25 mm			4	fringes
Window artifact size	Within the Window Aperture <sup>(3)</sup>			400	μm
Window aperture	See <sup>(4)</sup>				
Illumination overfill	Refer to <a href="#">Illumination Overfill</a>				
Window transmittance, single-pass through both surfaces and glass <sup>(5)</sup>	At wavelength 405 nm. Applies to 0° and 24° AOI only.	95%			
	Minimum within the wavelength range 420 nm to 680 nm. Applies to all angles 0° to 30° AOI.	97%			
	Average over the wavelength range 420 nm to 680 nm. Applies to all angles 30° to 45° AOI.	97%			

(1) See [Window Characteristics and Optics](#) for more information.

(2) At a wavelength of 632.8 nm.

(3) See the [Mechanical, Packaging, and Orderable Information](#) section at the end of this document for details regarding the size and location of the window aperture.

(4) For details regarding the size and location of the window aperture, see the package mechanical characteristics listed in the Mechanical ICD in the [Mechanical, Packaging, and Orderable Information](#).

(5) See the TI application report [DLPA031](#), *Wavelength Transmittance Considerations for DLP DMD Window*.

## 7.14 Chipset Component Usage Specification

The DLP7000 is a component of one or more DLP chipsets. Reliable function and operation of the DLP7000 requires that it be used in conjunction with the other components of the applicable DLP chipset, including those components that contain or implement TI DMD control technology. TI DMD control technology is the TI technology and devices for operating or controlling a DLP DMD.

## 8 Detailed Description

### 8.1 Overview

Optically, the DLP7000 consists of 786,432 highly reflective, digitally switchable, micrometer-sized mirrors ("micromirrors"), organized in a two-dimensional array of 1024 micromirror columns by 768 micromirror rows (Figure 12). Each aluminum micromirror is approximately 13.68 microns in size (see the "Micromirror Pitch" in Figure 12), and is switchable between two discrete angular positions:  $-12^\circ$  and  $+12^\circ$ . The angular positions are measured relative to a  $0^\circ$  "flat state", which is parallel to the array plane (see Figure 13). The tilt direction is perpendicular to the hinge-axis which is positioned diagonally relative to the overall array. The "On State" landed position is directed towards "Row 0, Column 0" (upper left) corner of the device package (see the "Micromirror Hinge-Axis Orientation" in Figure 12). In the field of visual displays, the 1024 by 768 "pixel" resolution is referred to as "XGA".

Each individual micromirror is positioned over a corresponding CMOS memory cell. The angular position of a specific micromirror is determined by the binary state (logic 0 or 1) of the corresponding CMOS memory cell contents, after the micromirror "clocking pulse" is applied. The angular position ( $-12^\circ$  or  $+12^\circ$ ) of the individual micromirrors changes synchronously with a micromirror "clocking pulse", rather than being synchronous with the CMOS memory cell data update. Therefore, writing a logic 1 into a memory cell followed by a micromirror "clocking pulse" will result in the corresponding micromirror switching to a  $+12^\circ$  position. Writing a logic 0 into a memory cell followed by a micromirror "clocking pulse" will result in the corresponding micromirror switching to a  $-12^\circ$  position.

Updating the angular position of the micromirror array consists of two steps. First, updating the contents of the CMOS memory. Second, application of a Micromirror Clocking Pulse to all or a portion of the micromirror array (depending upon the configuration of the system). Micromirror Clocking Pulses are generated externally by a DLPA200, with application of the pulses being coordinated by the DLPC410 controller.

Around the perimeter of the 1024 by 768 array of micromirrors is a uniform band of "border" micromirrors. The border micromirrors are not user-addressable. The border micromirrors land in the  $-12^\circ$  position once power has been applied to the device. There are 10 border micromirrors on each side of the 1024 by 768 active array.

Figure 8 shows a DLPC410 and DLP7000 Chipset Block Diagram. The DLPC410 and DLPA200 control and coordinate the data loading and micromirror switching for reliable DLP7000 operation. The DLPR410 is the programmed PROM required to properly configure the DLPC410 controller. For more information on the chipset components, see [Application and Implementation](#). For a typical system application using the DLP Discovery 4100 chipset including the DLP7000, see Figure 19.

### 8.2 Functional Block Diagram

Figure 8 is a simplified system block diagram showing the use of the following components:

- DLPC410 – Xilinx [XC5VLX30] FPGA configured to provide high-speed DMD data and control, and DLPA200 timing and control
- DLPR410 – [XCF16PFGS48C] serial flash PROM contains startup configuration information (EEPROM)
- DLPA200 – DMD micromirror driver for the DLP7000 DMD
- DLP7000 – Spatial Light Modulator (DMD)



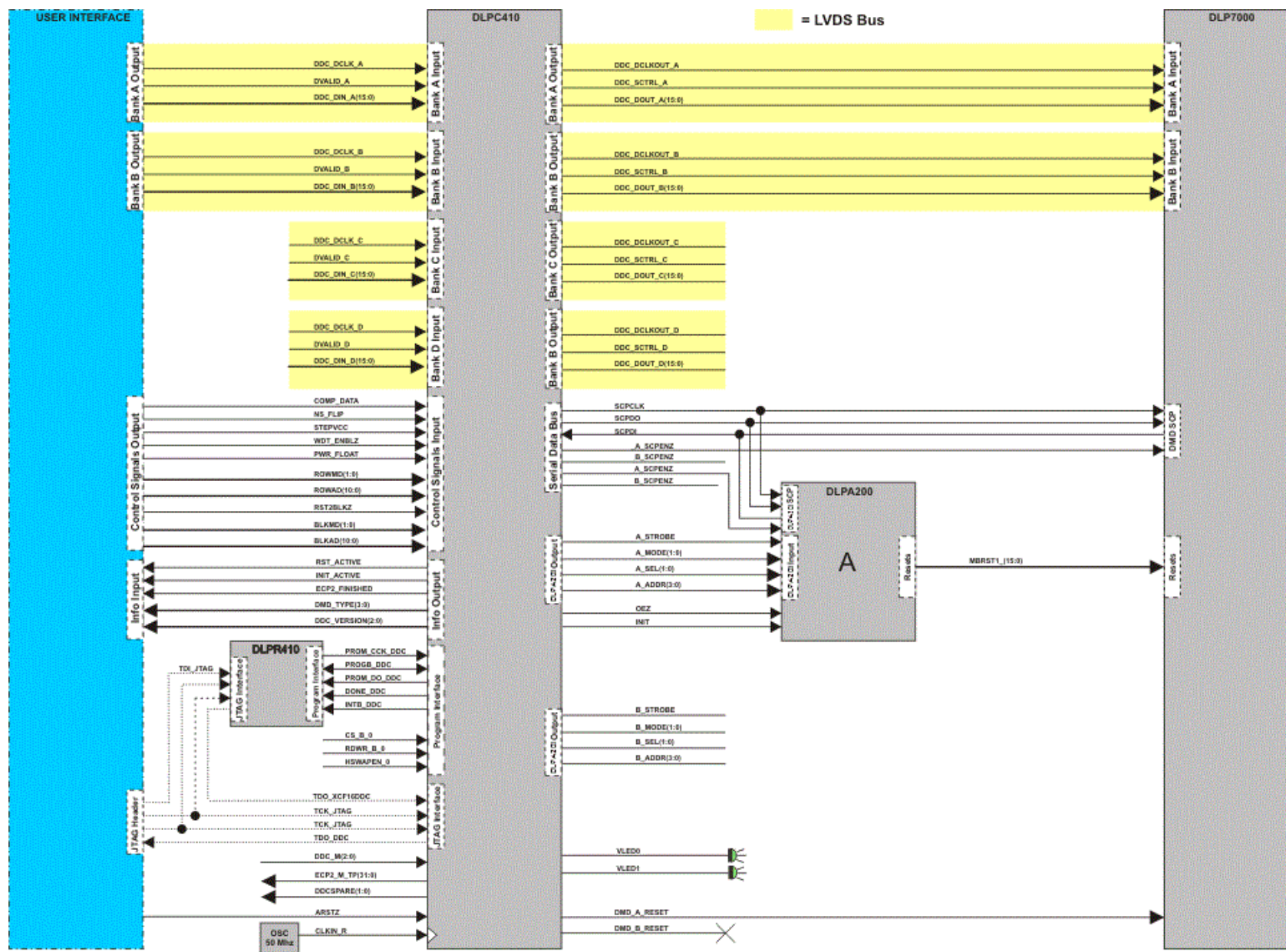


Figure 8. DLPC410 and DLP7000 Chipset Block Diagram

## 8.3 Feature Description

### 8.3.1 Discovery 4100 Chipset DMD Features

**Table 1. DLP7000 Overview**

DMD	ARRAY	PATTERNS/s	DATA RATE (Gbps)	MIRROR PITCH
DLP7000 - 0.7"XGA	1024 x 768	32552	25.6	13.6 $\mu$ m

#### 8.3.1.1 DLPC410 Controller

The DLP7000 chipset includes the DLPC410 controller which provides a high-speed LVDS data and control interface for DMD control. This interface is also connected to a second FPGA used to drive applications (not included in the chipset). The DLPC410 generates DMD and DLPA200 initialization and control signals in response to the inputs on the control interface.

For more information, see the DLPC410 data sheet [DLPS024](#).

#### 8.3.1.2 DLPA200 DMD Micromirror Driver

DLPA200 micromirror driver provides the micromirror clocking pulse driver functions for the DMD. One DLPA200 is required for DLP7000.

For more information on the DLPA200, see the DLPA200 data sheet [DLPS015](#).

#### 8.3.1.3 Flash Configuration PROM

The DLPC410 is configured at startup from the serial flash PROM. The contents of this PROM can not be altered. For more information, see the DLPC410 data sheet [DLPS024](#) and DLPR410 data sheet [DLPS027](#).

#### 8.3.1.4 DMD

##### 8.3.1.4.1 DLP7000 XGA Chip Set Interfaces

This section will describe the interface between the different components included in the chipset. For more information on component interfacing, see [Application and Implementation](#).

##### 8.3.1.4.1.1 DLPC410 Interface Description

##### 8.3.1.4.1.1.1 DLPC410 IO

[Table 2](#) describes the inputs and outputs of the DLPC410 to the user. For more details on these signals, see the DLPC410 data sheet ([DLPS024](#)).

**Table 2. Input/Output Description**

PIN NAME	DESCRIPTION	I/O
ARST	Asynchronous active low reset	I
CLKIN_R	Reference clock, 50 MHz	I
DIN_[A,B,C,D](15:0)	LVDS DDR input for data bus A,B,C,D (15:0)	I
DCLKIN[A,B,C,D]	LVDS inputs for data clock (200 - 400 MHz) on bus A, B, C, and D	I
DVALID[A,B,C,D]	LVDS input used to start write sequence for bus A, B, C, and D	I
ROWMD(1:0)	DMD row address and row counter control	I
ROWAD(10:0)	DMD row address pointer	I
BLK_AD(3:0)	DMD mirror block address pointer	I
BLK_MD(1:0)	DMD mirror block reset and clear command modes	I
PWR_FLOAT	Used to float DMD mirrors before complete loss of power	I
DMD_TYPE(3:0)	DMD type in use	O
RST_ACTIVE	Indicates DMD mirror reset in progress	O
INIT_ACTIVE	Initialization in progress.	O
VLED0	System "heartbeat" signal	O



**Table 2. Input/Output Description (continued)**

PIN NAME	DESCRIPTION	I/O
VLED1	Denotes initialization complete	O

#### 8.3.1.4.1.1.2 Initialization

The *INIT\_ACTIVE* (Table 2) signal indicates that the DLP7000, DLPA200, and DLPC410 are in an initialization state after power is applied. During this initialization period, the DLPC410 is initializing the DLP7000 and DLPA200 by setting all internal registers to their correct states. When this signal goes low, the system has completed initialization. System initialization takes approximately 220 ms to complete. Data and command write cycles should not be asserted during the initialization.

During initialization the user must send a training pattern to the DLPC410 on all data and DVALID lines to correctly align the data inputs to the data clock. For more information about the interface training pattern, see the DLPC410 data sheet (DLPS024).

#### 8.3.1.4.1.1.3 DMD Device Detection

The DLPC410 automatically detects the DMD type and device ID. *DMD\_TYPE* (Table 2) is an output from the DLPC410 that contains the DMD information. Only DMDs sold with the chipset or kit are recognized by the automatic detection function. All other DMDs do not operate with the DLPC410.

#### 8.3.1.4.1.1.4 Power Down

To ensure long term reliability of the DLP7000, a shutdown procedure must be executed. Prior to power removal, assert the *PWR\_FLOAT* (Table 2) signal and allow approximately 300  $\mu$ s for the procedure to complete. This procedure assures the mirrors are in a flat state.

### 8.3.1.4.2 DLPC410 to DMD Interface

#### 8.3.1.4.2.1 DLPC410 to DMD IO Description

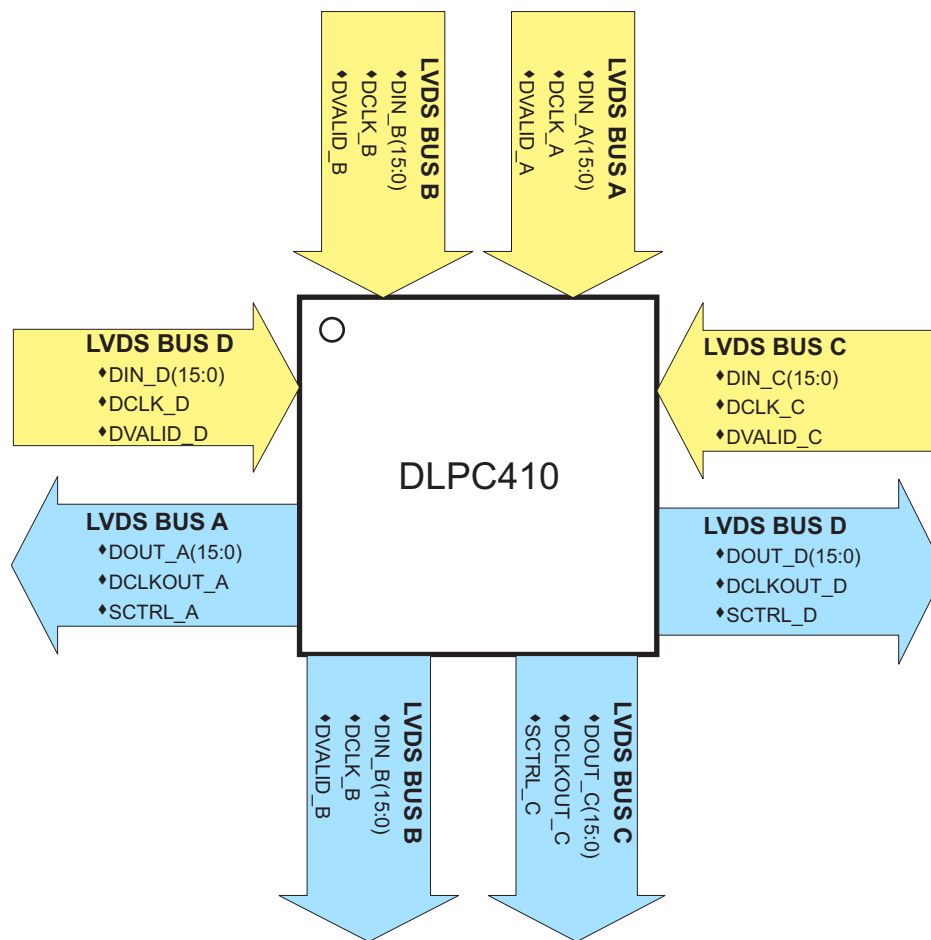
Table 3 lists the available controls and status pin names and their corresponding signal type, along with a brief functional description.

**Table 3. DLPC410 to DMD I/O Pin Descriptions**

PIN NAME	DESCRIPTION	I/O
DDC_DOUT_[A,B,C,D](15:0)	LVDS DDR output to DMD data bus A,B,C,D (15:0)	O
DDC_DCLKOUT_[A,B,C,D]	LVDS output to DMD data clock A,B,C,D	O
DDC_SCTRL_[A,B,C,D]	LVDS DDR output to DMD data control A,B,C,D	O

### 8.3.1.4.2.2 Data Flow

Figure 9 shows the data traffic through the DLPC410. Special considerations are necessary when laying out the DLPC410 to allow best signal flow.



**Figure 9. DLPC410 Data Flow**

Two LVDS buses transfer the data from the user to the DLPC410. Each bus has its data clock that is input edge aligned with the data (DCLK). Each bus also has its own validation signal that qualifies the data input to the DLPC410 (DVALID).

Output LVDS buses transfer data from the DLPC410 to the DLP7000. Output buses LVDS A and LVDS B are used as highlighted in Figure 9.

### 8.3.1.4.3 DLPC410 to DLPA200 Interface

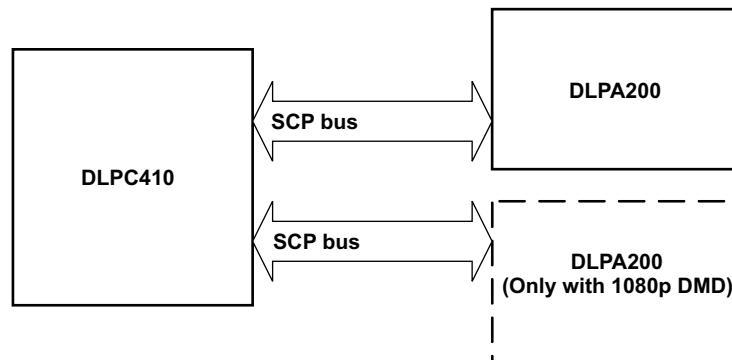
#### 8.3.1.4.3.1 DLPA200 Operation

The DLPA200 DMD Micromirror Driver is a mixed-signal Application Specific Integrated Circuit (ASIC) that combines the necessary high-voltage power supply generation and Micromirror Clocking Pulse functions for a family of DMDs. The DLPA200 is programmable and controllable to meet all current and anticipated DMD requirements.

The DLPA200 operates from a 12-V power supply input. For more detailed information on the DLPA200, see the DLPA200 data sheet.

#### 8.3.1.4.3.2 DLPC410 to DLPA200 IO Description

The Serial Communications Port (SCP) is a full duplex, synchronous, character-oriented (byte) port that allows exchange of commands from the DLPC410 to the DLPA200. One SCP bus is used for the DLP7000.



**Figure 10. Serial Port System Configuration**

There are five signal lines associated with the SCP bus:  $\overline{\text{SCPEN}}$ , SCPCK, SCPDI, SCPDO, and  $\overline{\text{IRQ}}$ .

Table 4 lists the available controls and status pin names and their corresponding signal type, along with a brief functional description.

**Table 4. DLPC410 to DLPA200 I/O Pin Descriptions**

PIN NAME	DESCRIPTION	I/O
A_SCPEN	Active low chip select for DLPA200 serial bus	O
A_STROBE	DLPA200 control signal strobe	O
A_MODE(1:0)	DLPA200 mode control	O
A_SEL(1:0)	DLPA200 select control	O
A_ADDR(3:0)	DLPA200 address control	O
B_SCPEN	Active low chip select for DLPA200 serial bus (2)	O
B_STROBE	DLPA200 control signal strobe (2)	O
B_MODE(1:0)	DLPA200 mode control	O
B_SEL(1:0)	DLPA200 select control	O
B_ADDR(3:0)	DLPA200 address control	O

The DLPA200 provides a variety of output options to the DMD by selecting logic control inputs: MODE[1:0], SEL[1:0] and reset group address A[3:0] (Table 4). The MODE[1:0] input determines whether a single output, two outputs, four outputs, or all outputs, will be selected. Output levels (VBIAS, VOFFSET, or VRESET) are selected by SEL[1:0] pins. Selected outputs are tri-stated on the rising edge of the STROBE signal and latched to the selected voltage level after a break-before-make delay. Outputs will remain latched at the last Micromirror Clocking Pulse waveform level until the next Micromirror Clocking Pulse waveform cycle.

#### 8.3.1.4.4 DLPA200 to DLP7000 Interface

##### 8.3.1.4.4.1 DLPA200 to DLP7000 Interface Overview

The DLPA200 generates three voltages: VBIAS, VRESET, and VOFFSET that are supplied to the DMD MBRST lines in various sequences through the Micromirror Clocking Pulse driver function. VOFFSET is also supplied directly to the DMD as DMDVCC2. A fourth DMD power supply, DMDVCC, is supplied directly to the DMD by regulators.

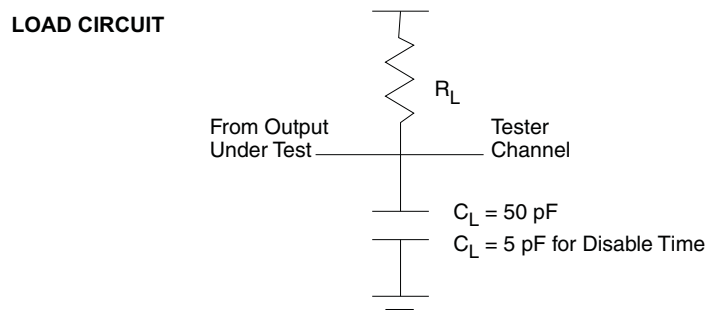
The function of the Micromirror Clocking Pulse driver is to switch selected outputs in patterns between the three voltage levels (VBIAS, VRESET and VOFFSET) to generate one of several Micromirror Clocking Pulse waveforms. The order of these Micromirror Clocking Pulse waveform events is controlled externally by the logic control inputs and timed by the STROBE signal. DLPC410 automatically detects the DMD type and then uses the DMD type to determine the appropriate Micromirror Clocking Pulse waveform.

A direct Micromirror Clocking Pulse operation causes a mirror to transition directly from one latched state to the next. The address must already be set up on the mirror electrodes when the Micromirror Clocking Pulse is initiated. Where the desired mirror display period does not allow for time to set up the address, a Micromirror Clocking Pulse with release can be performed. This operation allows the mirror to go to a relaxed state regardless of the address while a new address is set up, after which the mirror can be driven to a new latched state.

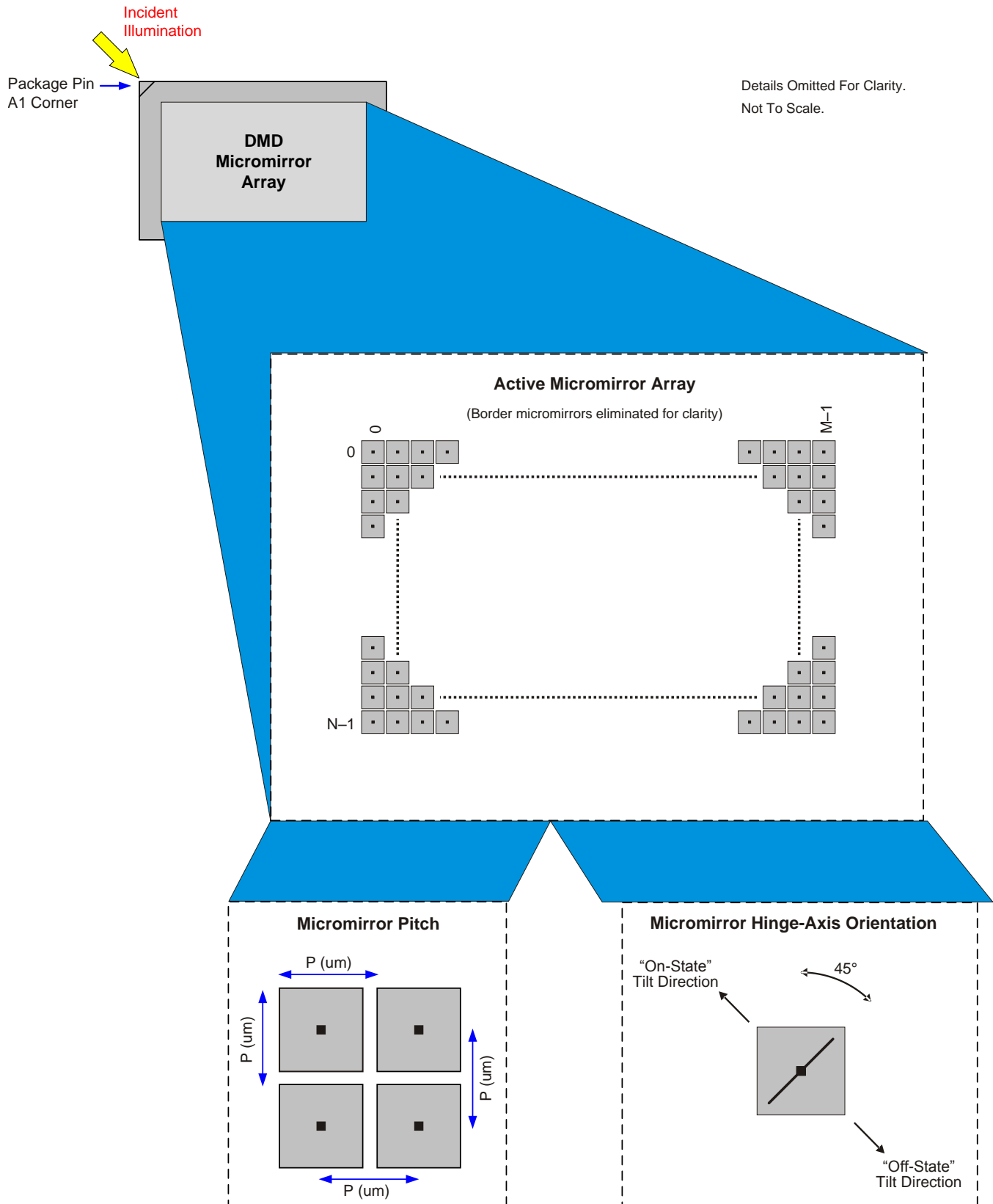
A mirror in the relaxed state typically reflects light into a system collection aperture and can be thought of as “off” although the light is likely to be more than a mirror latched in the “off” state. System designers should carefully evaluate the impact of relaxed mirror conditions on optical performance.

### 8.3.1.5 Measurement Conditions

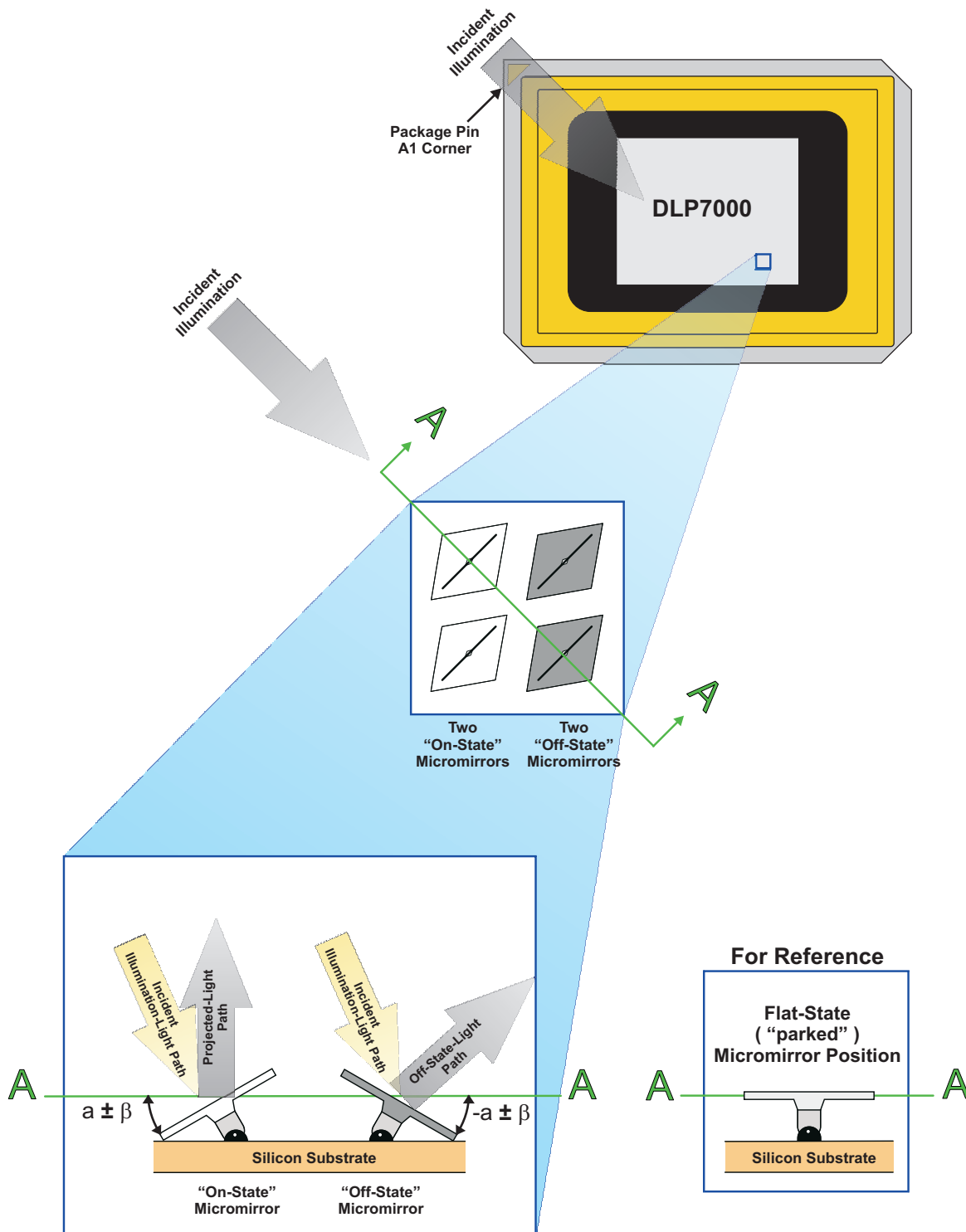
The data sheet provides timing at the device pin. For output timing analysis, the tester pin electronics and its transmission line effects must be taken into account. [Figure 11](#) shows an equivalent test load circuit for the output under test. The load capacitance value stated is only for characterization and measurement of AC timing signals. This load capacitance value does not indicate the maximum load the device is capable of driving. All rise and fall transition timing parameters are referenced to  $V_{IL}$  MAX and  $V_{IH}$  MIN for input clocks,  $V_{OL}$  MAX and  $V_{OH}$  MIN for output clocks.



**Figure 11. Test Load Circuit for AC Timing Measurements**



**Figure 12. DMD Micromirror Array, Pitch, and Hinge-Axis Orientation**



**Figure 13. Micromirror Landed Positions and Light Paths**

## 8.4 Device Functional Modes

### 8.4.1 DMD Operation

The DLP7000 has only one functional mode, it is set to be highly optimized for low latency and high speed in generating mirror clocking pulses and timings.

When operated with the DLPC410 controller in conjunction with the DLPA200 driver, the DLP7000 can be operated in several display modes. The DLP7000 is loaded as 16 blocks of 48 rows each. Figure 14, Figure 15, Figure 16, and Figure 17 show how the image is loaded by the different Micromirror Clocking Pulse modes.

There are four Micromirror Clocking Pulse modes that determine which blocks are "reset" when a Micromirror Clocking Pulse command is issued:

- Single block mode
- Dual block mode
- Quad block mode
- Global mode

#### 8.4.1.1 Single Block Mode

In single block mode, a single block can be loaded and reset in any order. After a block is loaded, it can be reset to transfer the information to the mechanical state of the mirrors.



Figure 14. Single Block Mode Diagram

#### 8.4.1.2 Dual Block Mode

In dual block mode, reset blocks are paired together as follows (0-1), (2-3), (4-5) . . . (14-15). These pairs can be reset in any order. After data is loaded a pair can be reset to transfer the information to the mechanical state of the mirrors.

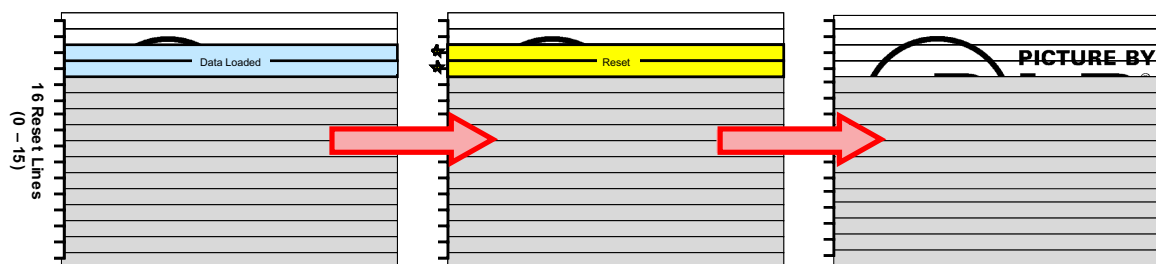
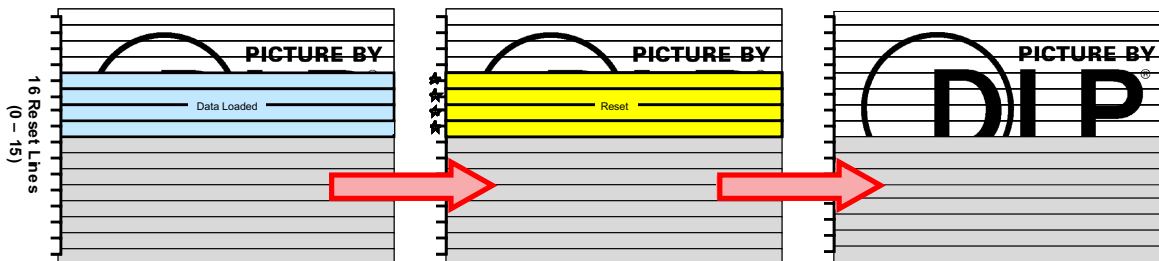


Figure 15. Dual Block Mode Diagram

## Device Functional Modes (continued)

### 8.4.1.3 Quad Block Mode

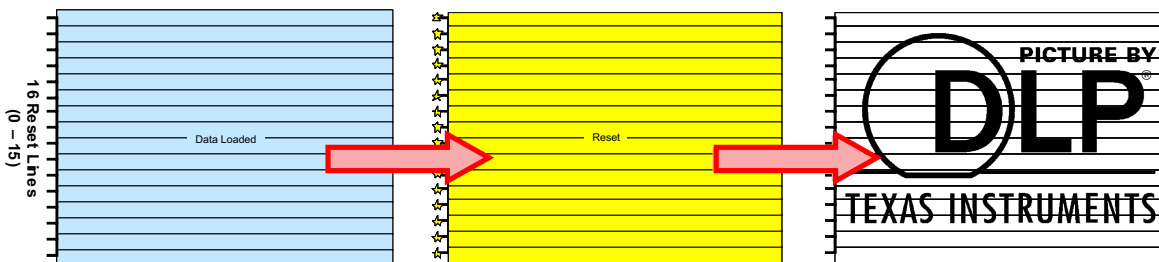
In quad block mode, reset blocks are grouped together in fours as follows (0-3), (4-7), (8-11) and (12-15). Each quad group can be randomly addressed and reset. After a quad group is loaded, it can be reset to transfer the information to the mechanical state of the mirrors.



**Figure 16. Quad Block Mode Diagram**

### 8.4.1.4 Global Mode

In global mode, all reset blocks are grouped into a single group and reset together. The entire DMD must be loaded with the desired data before issuing a Global Reset to transfer the information to the mechanical state of the mirrors.



**Figure 17. Global Mode Diagram**



## 8.5 Window Characteristics and Optics

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### NOTE

TI assumes no responsibility for image quality artifacts or DMD failures caused by optical system operating conditions exceeding limits described previously.

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### 8.5.1 Optical Interface and System Image Quality

TI assumes no responsibility for end-equipment optical performance. Achieving the desired end-equipment optical performance involves making trade-offs between numerous component and system design parameters. Optimizing system optical performance and image quality strongly relate to optical system design parameter trades. Although it is not possible to anticipate every conceivable application, projector image quality and optical performance is contingent on compliance to the optical system operating conditions described in the following sections.

### 8.5.2 Numerical Aperture and Stray Light Control

The angle defined by the numerical aperture of the illumination and projection optics at the DMD optical area should be the same. This angle should not exceed the nominal device mirror tilt angle unless appropriate apertures are added in the illumination and/or projection pupils to block out flat-state and stray light from the projection lens. The mirror tilt angle defines DMD capability to separate the "ON" optical path from any other light path, including undesirable flat-state specular reflections from the DMD window, DMD border structures, or other system surfaces near the DMD such as prism or lens surfaces. If the numerical aperture exceeds the mirror tilt angle, or if the projection numerical aperture angle is more than two degrees larger than the illumination numerical aperture angle, objectionable artifacts in the display's border and/or active area could occur.

### 8.5.3 Pupil Match

TI recommends the exit pupil of the illumination is nominally centered within 2° of the entrance pupil of the projection optics. Misalignment of pupils can create objectionable artifacts in the display's border and/or active area, which may require additional system apertures to control, especially if the numerical aperture of the system exceeds the pixel tilt angle.

### 8.5.4 Illumination Overfill

The active area of the device is surrounded by an aperture on the inside DMD window surface that masks structures of the DMD device assembly from normal view. The aperture is sized to anticipate several optical operating conditions. Overfill light illuminating the window aperture can create artifacts from the edge of the window aperture opening and other surface anomalies that may be visible on the screen. The illumination optical system should be designed to limit light flux incident anywhere on the window aperture from exceeding approximately 10% of the average flux level in the active area. Depending on the particular system's optical architecture, overfill light may have to be further reduced below the suggested 10% level in order to be acceptable.

## 8.6 Micromirror Array Temperature Calculation

Achieving optimal DMD performance requires proper management of the maximum DMD case temperature, the maximum temperature of any individual micromirror in the active array, the maximum temperature of the window aperture, and the temperature gradient between case temperature and the predicted micromirror array temperature. (see [Figure 18](#)).

See the [Recommended Operating Conditions](#) for applicable temperature limits.

### 8.6.1 Package Thermal Resistance

The DMD is designed to conduct absorbed and dissipated heat to the back of the Type A package where it can be removed by an appropriate heat sink. The heat sink and cooling system must be capable of maintaining the package within the specified operational temperatures, refer to [Figure 18](#). The total heat load on the DMD is typically driven by the incident light absorbed by the active area; although other contributions include light energy absorbed by the window aperture and electrical power dissipation of the array.

### 8.6.2 Case Temperature

The temperature of the DMD case can be measured directly. For consistency, a Thermal Test Point locations 1 and 2 are defined, as shown in [Figure 18](#).

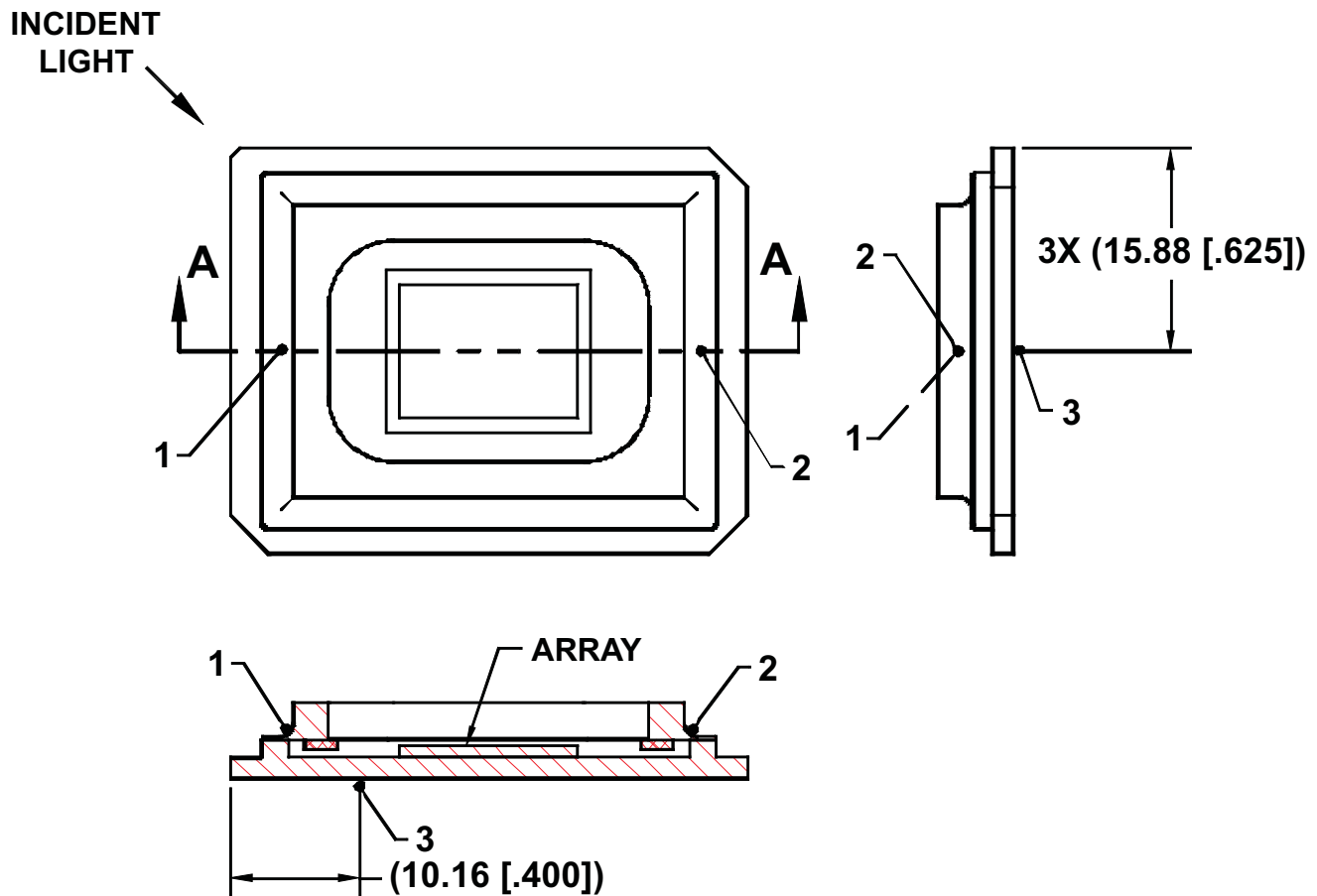


Figure 18. Thermal Test Point Location

## Micromirror Array Temperature Calculation (continued)

### 8.6.3 Micromirror Array Temperature Calculation

Micromirror array temperature cannot be measured directly; therefore, it must be computed analytically from measurement points ([Figure 18](#)), the package thermal resistance, the electrical power, and the illumination heat load. The relationship between micromirror array temperature and the case temperature are provided by [Equation 1](#) and [Equation 2](#):

$$T_{\text{Array}} = T_{\text{Ceramic}} + (Q_{\text{Array}} \times R_{\text{Array-To-Ceramic}}) \quad (1)$$

$$Q_{\text{Array}} = Q_{\text{ELE}} + Q_{\text{ILL}}$$

Where the following elements are defined as:

- $T_{\text{Array}}$  = computed micromirror array temperature (°C)
- $T_{\text{Ceramic}}$  = Ceramic temperature (°C) (TC2 Location [Figure 18](#))
- $Q_{\text{Array}}$  = Total DMD array power (electrical + absorbed) (measured in Watts)
- $R_{\text{Array-To-Ceramic}}$  = thermal resistance of DMD package from array to TC2 (°C/W) (see [Package Thermal Resistance](#))
- $Q_{\text{ELE}}$  = Nominal electrical power (W)
- $Q_{\text{ILL}}$  = Absorbed illumination energy (W) (2)

An example calculation is provided below based on a traditional DLP Video projection system. The electrical power dissipation of the DMD is variable and depends on the voltages, data rates, and operating frequencies. The nominal electrical power dissipation to be used in the calculation is 2 Watts. Thus,  $Q_{\text{ELE}} = 2$  Watts. The absorbed power from the illumination source is variable and depends on the operating state of the mirrors and the intensity of the light source. Based on modeling and measured data from DLP projection system

$$Q_{\text{ILL}} = C_{\text{L2W}} \times \text{SL}$$

where

- $C_{\text{L2W}}$  is a Lumens to Watts constant, and can be estimated at 0.00274 W/lm
- SL = Screen Lumens nominally measured to be 2000 lm
- $Q_{\text{array}} = 2.0 + (0.00274 \times 2000) = 7.48$  W, Estimated total power on micromirror Array
- $T_{\text{Ceramic}} = 55^\circ\text{C}$ , assumed system measurement
- Finally,  $T_{\text{Array}}$  (micromirror active array temperature) is
- $T_{\text{Array}} = 55^\circ\text{C} + (7.48 \text{ W} \times 0.9^\circ\text{C/W}) = 61.7^\circ\text{C}$  (3)

## 8.7 Micromirror Landed-On/Landed-Off Duty Cycle

### 8.7.1 Definition of Micromirror Landed-On/Landed-Off Duty Cycle

The micromirror landed-on/landed-off duty cycle (landed duty cycle) denotes the amount of time (as a percentage) that an individual micromirror is landed in the On-state versus the amount of time the same micromirror is landed in the Off-state.

As an example, a landed duty cycle of 100/0 indicates that the referenced pixel is in the On-state 100% of the time (and in the Off-state 0% of the time); whereas 0/100 would indicate that the pixel is in the Off-state 100% of the time. Likewise, 50/50 indicates that the pixel is On 50% of the time and Off 50% of the time.

Note that when assessing landed duty cycle, the time spent switching from one state (ON or OFF) to the other state (OFF or ON) is considered negligible and is thus ignored.

Since a micromirror can only be landed in one state or the other (On or Off), the two numbers (percentages) always add to 100.

### 8.7.2 Landed Duty Cycle and Useful Life of the DMD

Knowing the long-term average landed duty cycle (of the end product or application) is important because subjecting all (or a portion) of the DMD's micromirror array (also called the active array) to an asymmetric landed duty cycle for a prolonged period of time can reduce the DMD's usable life.

## Micromirror Landed-On/Landed-Off Duty Cycle (continued)

Note that it is the symmetry/asymmetry of the landed duty cycle that is of relevance. The symmetry of the landed duty cycle is determined by how close the two numbers (percentages) are to being equal. For example, a landed duty cycle of 50/50 is perfectly symmetrical whereas a landed duty cycle of 100/0 or 0/100 is perfectly asymmetrical.

### 8.7.3 Landed Duty Cycle and Operational DMD Temperature

Operational DMD Temperature and Landed Duty Cycle interact to affect the DMD's usable life, and this interaction can be exploited to reduce the impact that an asymmetrical Landed Duty Cycle has on the DMD's usable life. This is quantified in the de-rating curve shown in [Figure 1](#). The importance of this curve is that:

- All points along this curve represent the same usable life.
- All points above this curve represent lower usable life (and the further away from the curve, the lower the usable life).
- All points below this curve represent higher usable life (and the further away from the curve, the higher the usable life).

In practice, this curve specifies the Maximum Operating DMD Temperature that the DMD should be operated at for a give long-term average Landed Duty Cycle.

### 8.7.4 Estimating the Long-Term Average Landed Duty Cycle of a Product or Application

During a given period of time, the Landed Duty Cycle of a given pixel follows from the image content being displayed by that pixel.

For example, in the simplest case, when displaying pure-white on a given pixel for a given time period, that pixel will experience a 100/0 Landed Duty Cycle during that time period. Likewise, when displaying pure-black, the pixel will experience a 0/100 Landed Duty Cycle.

Between the two extremes (ignoring for the moment color and any image processing that may be applied to an incoming image), the Landed Duty Cycle tracks one-to-one with the gray scale value, as shown in [Table 5](#).

**Table 5. Grayscale Value and Landed Duty Cycle**

GRAYSCALE VALUE	LANDED DUTY CYCLE
0%	0/100
10%	10/90
20%	20/80
30%	30/70
40%	40/60
50%	50/50
60%	60/40
70%	70/30
80%	80/20
90%	90/10
100%	100/0

Accounting for color rendition (but still ignoring image processing) requires knowing both the color intensity (from 0% to 100%) for each constituent primary color (red, green, and/or blue) for the given pixel as well as the color cycle time for each primary color, where "color cycle time" is the total percentage of the frame time that a given primary must be displayed in order to achieve the desired white point.

During a given period of time, the landed duty cycle of a given pixel can be calculated as follows:

$$\text{Landed Duty Cycle} = (\text{Red\_Cycle\_}\% \times \text{Red\_Scale\_Value}) + (\text{Green\_Cycle\_}\% \times \text{Green\_Scale\_Value}) + (\text{Blue\_Cycle\_}\% \times \text{Blue\_Scale\_Value})$$

where

- Red\_Cycle\_%, Green\_Cycle\_%, and Blue\_Cycle\_%, represent the percentage of the frame time that Red, Green, and Blue are displayed (respectively) to achieve the desired white point. (4)

For example, assume that the red, green and blue color cycle times are 50%, 20%, and 30% respectively (in order to achieve the desired white point), then the Landed Duty Cycle for various combinations of red, green, blue color intensities would be as shown in [Table 6](#).

**Table 6. Example Landed Duty Cycle for Full-Color**

RED CYCLE PERCENTAGE 50%	GREEN CYCLE PERCENTAGE 20%	BLUE CYCLE PERCENTAGE 30%	LANDED DUTY CYCLE
RED SCALE VALUE	GREEN SCALE VALUE	BLUE SCALE VALUE	
0%	0%	0%	0/100
100%	0%	0%	50/50
0%	100%	0%	20/80
0%	0%	100%	30/70
12%	0%	0%	6/94
0%	35%	0%	7/93
0%	0%	60%	18/82
100%	100%	0%	70/30
0%	100%	100%	50/50
100%	0%	100%	80/20
12%	35%	0%	13/87
0%	35%	60%	25/75
12%	0%	60%	24/76
100%	100%	100%	100/0

## 9 Application and Implementation

### NOTE

Information in the following applications sections is not part of the TI component specification, and TI does not warrant its accuracy or completeness. TI's customers are responsible for determining suitability of components for their purposes. Customers should validate and test their design implementation to confirm system functionality.

### 9.1 Application Information

The DLP7000 devices require they be coupled with the DLPC410 controller to provide a reliable solution for many different applications. The DMDs are spatial light modulators which reflect incoming light from an illumination source to one of two directions, with the primary direction being into a projection collection optic. Each application is derived primarily from the optical architecture of the system and the format of the data coming into the DLPC410. Applications of interest include 3D measurement systems, lithography, medical systems, and compressive sensing.

#### 9.1.1 Device Description

The DLP7000 XGA chipset offers developers a convenient way to design a wide variety of industrial, medical, telecom and advanced display applications by delivering maximum flexibility in formatting data, sequencing data, and light patterns.

The DLP7000 XGA chipset includes the following four components: DMD Digital Controller (DLPC410), EEPROM (DLPR410), DMD Micromirror Driver (DLPA200), and a DMD (DLP7000).

##### **DLPC410** DMD Digital Controller

- Provides high speed LVDS data and control interface to the DLP7000.
- Drives mirror clocking pulse and timing information to the DLPA200.
- Supports random row addressing.

##### **DLPR410** EEPROM

- Contains startup configuration information for the DLPC410.

##### **DLPA200** DMD Micromirror Driver

- Generates Micromirror Clocking Pulse control (sometimes referred to as a "Reset") of DMD mirrors.

##### **DLP7000:** Digital Micromirror Device

- Steers light in two digital positions (+12° and -12°) using 1024 x 768 micromirror array of aluminum mirrors.

**Table 7. DLP Discovery 4100 Chipset Configuration for 0.7 XGA Chipset**

QUANTITY	TI PART	DESCRIPTION
1	DLP7000	0.7 XGA Type A DMD (digital micromirror device)
1	DLPC410	DLP Discovery 4100 DMD controller
1	DLPR410	DLP Discovery 4100 configuration PROM
1	DLPA200	DMD micromirror driver

Reliable function and operation of DLP7000 XGA chipsets require the components be used in conjunction with each other. This document describes the proper integration and use of the DLP7000 XGA chipset components.

The DLP7000 XGA chipset can be combined with a user programmable Application FPGA (not included) to create high performance systems.

## 9.2 Typical Application

A typical embedded system application using the DLPC410 controller and DLP7000 is shown in Figure 19. In this configuration, the DLPC410 controller supports input from an FPGA. The FPGA sends low-level data to the controller, enabling the system to be highly optimized for low latency and high speed.

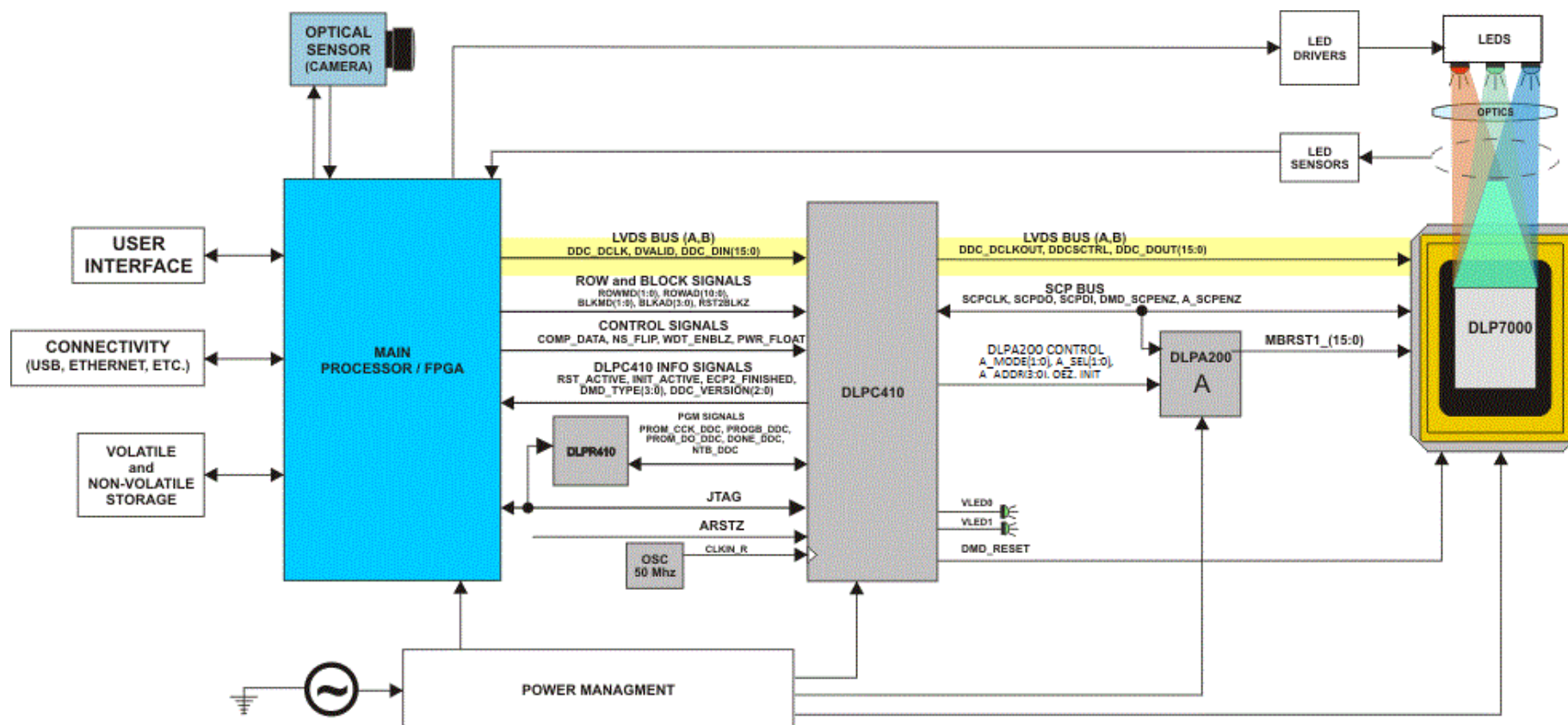


Figure 19. DLPC410 and DLP7000 Embedded Example Block Diagram

## 9.2.1 Design Requirements

All applications using the DLP7000 XGA chipset require both the controller and the DMD components for operation. The system also requires an external parallel flash memory device loaded with the DLPC410 Configuration and Support Firmware. The chipset has several system interfaces and requires some support circuitry. The following interfaces and support circuitry are required:

- DLPC410 System Interfaces:
  - Control Interface
  - Trigger Interface
  - Input Data Interface
  - Illumination Interface
  - Reference Clock
- DLP7000 Interfaces:
  - DLPC410 to DLP7000 Digital Data
  - DLPC410 to DLP7000 Control Interface
  - DLPC410 to DLP7000 Micromirror Reset Control Interface
  - DLPC410 to DLPA200 Micromirror Driver
  - DLPA200 to DLP7000 Micromirror Reset

## 9.2.2 Detailed Design Procedure

The DLP7000 DMD is well suited for visible light applications requiring fast, spatially programmable light patterns using the micromirror array. See the [Functional Block Diagram](#) to see the connections between the DLP7000 DMD, the DLPC410 digital controller, the DLPR410 EEPROM, and the DLPA200 DMD micromirror drivers. See the [Figure 19](#) for an application example. Follow the [Layout Guidelines](#) for reliability.



## 10 Power Supply Recommendations

### 10.1 DMD Power-Up and Power-Down Procedures

Repeated failure to adhere to the prescribed power-up and power-down procedures may affect device reliability. The DLP7000 power-up and power-down procedures are defined by the DLPC410 data sheet ([DLPS024](#)) and the DLP Discovery Chipset data sheet ([DLPU008](#)). These procedures must be followed to ensure reliable operation of the device.

## 11 Layout

### 11.1 Layout Guidelines

The DLP7000 is part of a chipset that is controlled by the DLPC410 in conjunction with the DLPA200. These guidelines are targeted at designing a PCB board with these components.

A target impedance of 50  $\Omega$  for single ended signals and 100  $\Omega$  between LVDS signals is specified for all signal layers.

#### 11.1.1 Impedance Requirements

Signals should be routed to have a matched impedance of 50  $\Omega \pm 10\%$  except for LVDS differential pairs (DMD\_DAT\_Xnn, DMD\_DCKL\_Xn, and DMD\_SCTRL\_Xn), which should be matched to 100  $\Omega \pm 10\%$  across each pair.

#### 11.1.2 PCB Signal Routing

When designing a PCB for the DLP7000 controlled by the DLPC410 in conjunction with the DLPA200, the following are recommended:

Signal trace corners should be no sharper than 45°. Adjacent signal layers should have the predominate traces routed orthogonal to each other. TI recommends that critical signals be hand routed in the following order: DDR2 Memory, DMD (LVDS signals), then DLPA200 signals.

TI does not recommend signal routing on power or ground planes.

TI does not recommend ground plane slots.

High speed signal traces should not cross over slots in adjacent power and/or ground planes.

**Table 8. Important Signal Trace Constraints**

SIGNAL	CONSTRAINTS
LVDS (DMD_DAT_xnn, DMD_DCKL_xn, and DMD_SCTRL_xn)	P-to-N data, clock, and SCTRL: <10 mils (0.25 mm); Pair-to-pair <10 mils (0.25 mm); Bundle-to-bundle <2000 mils (50 mm, for example DMD_DAT_Ann to DMD_DAT_Bnn) Trace width: 4 mil (0.1 mm) Trace spacing: In ball field – 4 mil (0.11 mm); PCB etch – 14 mil (0.36 mm) Maximum recommended trace length <6 inches (150 mm)

**Table 9. Power Trace Widths and Spacing**

SIGNAL NAME	MINIMUM TRACE WIDTH	MINIMUM TRACE SPACING	LAYOUT REQUIREMENTS
GND	Maximize	5 mil (0.13 mm)	Maximize trace width to connecting pin as a minimum
VCC, VCC2	20 mil (0.51 mm)	10 mil (0.25 mm)	
MBRST[15:0]	11 mil (0.23 mm)	15 mil (0.38 mm)	

### 11.1.3 Fiducials

Fiducials for automatic component insertion should be 0.05-inch copper with a 0.1-inch cutout (antipad). Fiducials for optical auto insertion are placed on three corners of both sides of the PCB.

### 11.1.4 DMD Interface

The digital interface from the DLPC410 to the DMD are LVDS signals that run at clock rates up to 400 MHz. Data is clocked into the DMD on both the rising and falling edge of the clock, so the data rate is 800 MHz. The LVDS signals should have 100  $\Omega$  differential impedance. The differential signals should be matched but kept as short as possible. Parallel termination at the LVDS receiver is in the DMD; therefore, on board termination is not necessary.

#### 11.1.4.1 Trace Length Matching

The DLPC410 DMD data signals require precise length matching. Differential signals should have impedance of 100 $\Omega$  (with 5% tolerance). It is important that the propagation delays are matched. The maximum differential pair uncoupled length is 100 mils with a relative propagation delay of  $\pm 25$  mil between the p and n. Matching all signals exactly will maximize the channel margin. The signal path through all boards, flex cables and internal DMD routing must be considered in this calculation.

### 11.1.5 DLP7000 Decoupling

General decoupling capacitors for the DLP7000 should be distributed around the PCB and placed to minimize the distance from IC voltage and ground pads. Each decoupling capacitor (0.1  $\mu$ F recommended) should have vias directly to the ground and power planes. Via sharing between components (discrete or integrated) is discouraged. The power and ground pads of the DLP7000 should be tied to the voltage and ground planes with their own vias.

#### 11.1.5.1 Decoupling Capacitors

Decoupling capacitors should be placed to minimize the distance from the decoupling capacitor to the supply and ground pin of the component. It is recommended that the placement of and routing for the decoupling capacitors meet the following guidelines:

- The supply voltage pin of the capacitor should be located close to the device supply voltage pin(s). The decoupling capacitor should have vias to ground and voltage planes. The device can be connected directly to the decoupling capacitor (no via) if the trace length is less than 0.1 inch. Otherwise, the component should be tied to the voltage or ground plane through separate vias.
- The trace lengths of the voltage and ground connections for decoupling capacitors and components should be less than 0.1 inch to minimize inductance.
- The trace width of the power and ground connection to decoupling capacitors and components should be as wide as possible to minimize inductance.
- Connecting decoupling capacitors to ground and power planes through multiple vias can reduce inductance and improve noise performance.
- Decoupling performance can be improved by utilizing low ESR and low ESL capacitors.

### 11.1.6 VCC and VCC2

The VCC pins of the DMD should be connected directly to the DMD VCC plane. Decoupling for the VCC should be distributed around the DMD and placed to minimize the distance from the voltage and ground pads. Each decoupling capacitor should have vias directly connected to the ground and power planes. The VCC and GND pads of the DMD should be tied to the VCC and ground planes with their own vias.

The VCC2 voltage can be routed to the DMD as a trace. Decoupling capacitors should be placed to minimize the distance from the DMD's VCC2 and ground pads. Using wide etch from the decoupling capacitors to the DMD connection will reduce inductance and improve decoupling performance.

### 11.1.7 DMD Layout

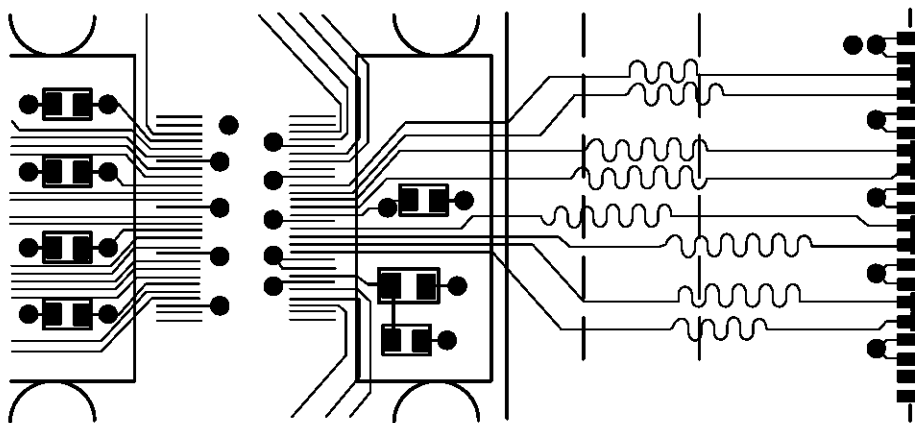
See the respective sections in this data sheet for package dimensions, timing and pin out information.

### 11.1.8 DLPA200

The DLPA200 generates the micromirror clocking pulses for the DMD. The DMD-drive outputs from the DLPA200 (MBRST[15:0]) should be routed with minimum trace width of 11 mil and a minimum spacing of 15 mil. The VCC and VCC2 traces from the output capacitors to the DLPA200 should also be routed with a minimum trace width and spacing of 11 mil and 15 mil, respectively. See the DLPA200 customer data sheet for mechanical package and layout information.

### 11.2 Layout Example

For LVDS (and other differential signal) pairs and groups, it is important to match trace lengths. In the area of the dashed lines, [Figure 20](#) shows correct matching of signal pair lengths with serpentine sections to maintain the correct impedance.



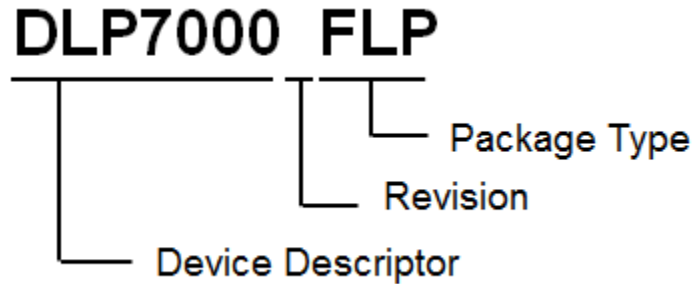
**Figure 20. Mitering LVDS Traces to Match Lengths**

## 12 Device and Documentation Support

### 12.1 Device Support

#### 12.1.1 Device Nomenclature

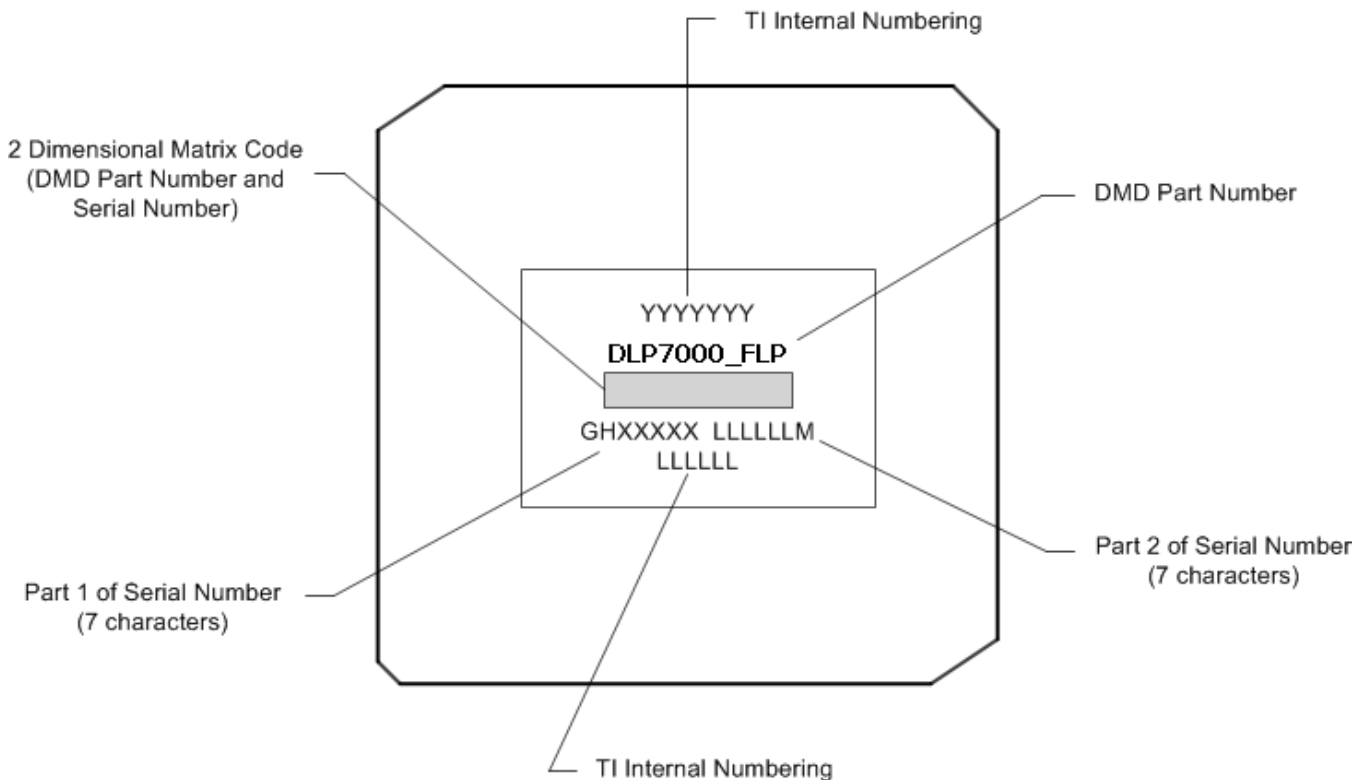
Figure 21 provides a legend of reading the complete device name for any DLP device.



**Figure 21. Device Nomenclature**

#### 12.1.1.1 Device Marking

The device marking consists of the fields shown in Figure 22.



**Figure 22. Device Marking**

## 12.2 Documentation Support

### 12.2.1 Related Documents

The following documents contain additional information related to the use of the DLP7000 device:

- DLP Discovery 4100 Chipset data sheet, [DLPU008](#)
- DLPC410 Digital Controller data sheet, [DLPS024](#)
- DLPA200 DMD Micromirror Driver data sheet, [DLPS015](#)
- DLPR410 EEPROM data sheet, [DLPS027](#)

### 12.3 Related Links

The table below lists quick access links. Categories include technical documents, support and community resources, tools and software, and quick access to sample or buy.

**Table 10. Related Links**

PARTS	PRODUCT FOLDER	SAMPLE & BUY	TECHNICAL DOCUMENTS	TOOLS & SOFTWARE	SUPPORT & COMMUNITY
DLP7000	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>
DLPA200	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>
DLPC410	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>	<a href="#">Click here</a>

### 12.4 Trademarks

Discovery is a trademark of Texas Instruments.

DLP is a registered trademark of Texas Instruments.

All other trademarks are the property of their respective owners.

### 12.5 Electrostatic Discharge Caution



These devices have limited built-in ESD protection. The leads should be shorted together or the device placed in conductive foam during storage or handling to prevent electrostatic damage to the MOS gates.

### 12.6 Glossary

[SLYZ022](#) — *TI Glossary*.

This glossary lists and explains terms, acronyms, and definitions.

## 13 Mechanical, Packaging, and Orderable Information

The following pages include mechanical, packaging, and orderable information. This information is the most current data available for the designated devices. This data is subject to change without notice and revision of this document. For browser-based versions of this data sheet, refer to the left-hand navigation.

## PACKAGING INFORMATION

Orderable Device	Status (1)	Package Type	Package Drawing	Pins	Package Qty	Eco Plan (2)	Lead/Ball Finish (6)	MSL Peak Temp (3)	Op Temp (°C)	Device Marking (4/5)	Samples
DLP7000BFLP	ACTIVE	LCCC	FLP	203	3	Green (RoHS & no Sb/Br)	W NIPDAU	N / A for Pkg Type			<a href="#">Samples</a>
DLP7000FLP	LIFEBUY	LCCC	FLP	203	3	Green (RoHS & no Sb/Br)	W NIAU	N / A for Pkg Type			

(1) The marketing status values are defined as follows:

**ACTIVE:** Product device recommended for new designs.

**LIFEBUY:** TI has announced that the device will be discontinued, and a lifetime-buy period is in effect.

**NRND:** Not recommended for new designs. Device is in production to support existing customers, but TI does not recommend using this part in a new design.

**PREVIEW:** Device has been announced but is not in production. Samples may or may not be available.

**OBsolete:** TI has discontinued the production of the device.

(2) Eco Plan - The planned eco-friendly classification: Pb-Free (RoHS), Pb-Free (RoHS Exempt), or Green (RoHS & no Sb/Br) - please check <http://www.ti.com/productcontent> for the latest availability information and additional product content details.

**TBD:** The Pb-Free/Green conversion plan has not been defined.

**Pb-Free (RoHS):** TI's terms "Lead-Free" or "Pb-Free" mean semiconductor products that are compatible with the current RoHS requirements for all 6 substances, including the requirement that lead not exceed 0.1% by weight in homogeneous materials. Where designed to be soldered at high temperatures, TI Pb-Free products are suitable for use in specified lead-free processes.

**Pb-Free (RoHS Exempt):** This component has a RoHS exemption for either 1) lead-based flip-chip solder bumps used between the die and package, or 2) lead-based die adhesive used between the die and leadframe. The component is otherwise considered Pb-Free (RoHS compatible) as defined above.

**Green (RoHS & no Sb/Br):** TI defines "Green" to mean Pb-Free (RoHS compatible), and free of Bromine (Br) and Antimony (Sb) based flame retardants (Br or Sb do not exceed 0.1% by weight in homogeneous material)

(3) MSL, Peak Temp. - The Moisture Sensitivity Level rating according to the JEDEC industry standard classifications, and peak solder temperature.

(4) There may be additional marking, which relates to the logo, the lot trace code information, or the environmental category on the device.

(5) Multiple Device Markings will be inside parentheses. Only one Device Marking contained in parentheses and separated by a "~" will appear on a device. If a line is indented then it is a continuation of the previous line and the two combined represent the entire Device Marking for that device.

(6) Lead/Ball Finish - Orderable Devices may have multiple material finish options. Finish options are separated by a vertical ruled line. Lead/Ball Finish values may wrap to two lines if the finish value exceeds the maximum column width.

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In no event shall TI's liability arising out of such information exceed the total purchase price of the TI part(s) at issue in this document sold by TI to Customer on an annual basis.

4

3

2

1

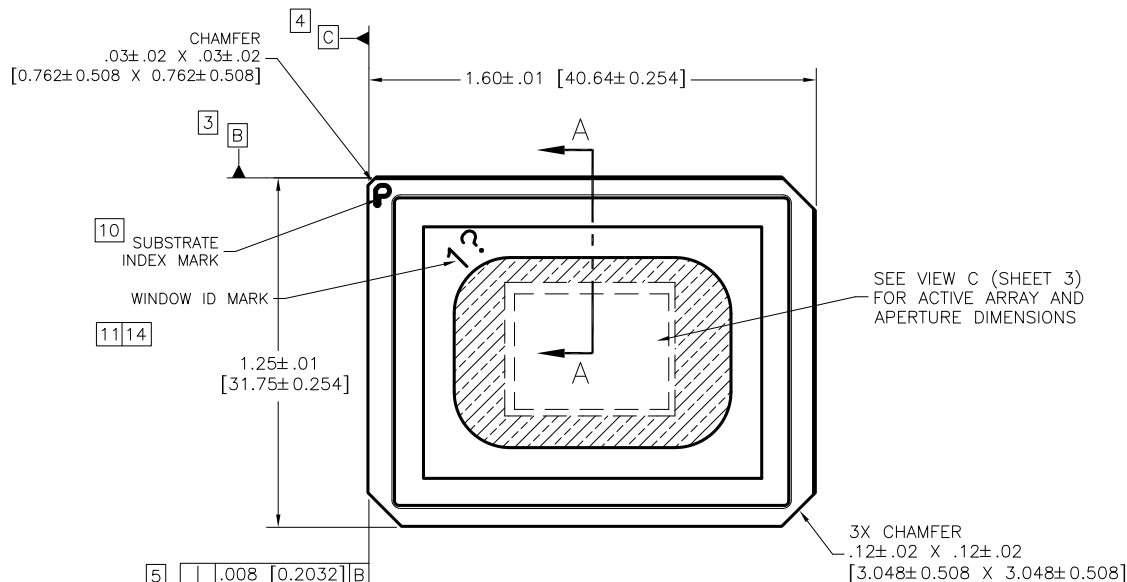
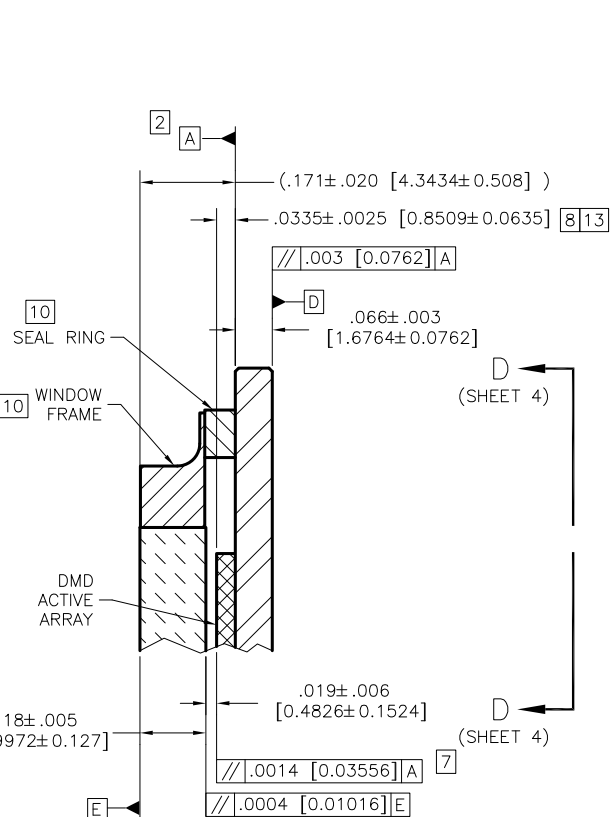
NOTES: UNLESS OTHERWISE SPECIFIED:

1. INTERPRET DIMENSIONS IN ACCORDANCE WITH ASME Y14.5M-1994.
2. DATUM A (SYSTEM INTERFACE PLANE) ESTABLISHED BY THREE DATUM AREAS SHOWN IN VIEW B (SHEET 2).
3. DATUM B ESTABLISHED BY TWO DATUM AREAS SHOWN IN VIEW B (SHEET 2).
4. DATUM C ESTABLISHED BY DATUM AREA SHOWN IN VIEW B (SHEET 2).
5. SUBSTRATE EDGE PERPENDICULARITY TOLERANCE APPLIES TO ENTIRE SURFACE.
6. LOCALIZED BACKSIDE SURFACE FLATNESS APPLIES TO ENTIRE CERAMIC SURFACE.
7. DIE PARALLELISM TOLERANCE APPLIES TO DMD ACTIVE ARRAY ONLY.
8. DIE HEIGHT TOLERANCE APPLIES TO CENTER OF DMD ACTIVE ARRAY ONLY.
9. ROTATION ANGLE OF DMD ACTIVE ARRAY IS A REFINEMENT OF THE LOCATION TOLERANCE AND IS THE MAXIMUM VALUE ALLOWED.
10. SUBSTRATE INDEX MARK, SYMBOLIZATION PAD, SEAL RING, AND WINDOW FRAME TO BE ELECTRICALLY CONNECTED TO VSS PLANE IN SUBSTRATE.
11. WINDOW SHALL BE ORIENTED SUCH THAT WINDOW ID MARK ALIGNS WITH SUBSTRATE INDEX MARK AS SHOWN.
12. THE OUTER DIMENSIONS OF THE SYMBOLIZATION PAD REPRESENT THE APPROXIMATE SIZE AND LOCATION OF THE RECOMMENDED THERMAL INTERFACE AREA.
13. DMD ACTIVE ARRAY DIMENSIONS ARE RELATED TO DATUM A (PRIMARY), DATUM B (SECONDARY), AND DATUM C (TERTIARY).
14. ? IS A WILD CARD CHARACTER AND CAN BE ANY LETTER.

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## REVISIONS

REV	DESCRIPTION	DATE	APPROVED
A	ECO 2071155, INITIAL RELEASE	07/24/06	MRW
B	ECO 2077187, CHG DESG FROM 29	02/19/07	MRW



ITEM NO	PART OR IDENTIFYING NUMBER	NOMENCLATURE OR DESCRIPTION	NOTES
1	Q314DA	ICD, MECHANICAL, DMD .7XGA 2X LVDS TYPE A	
2			
3			
4			
5			
6			
7			
8			
9			
10			
11			
12			
13			
14			



THIRD ANGLE PROJECTION

NONE Q314DA

NEXT ASSY USED ON

APPLICATION

UNLESS OTHERWISE SPECIFIED:

DIMENSIONS ARE IN INCHES [MILLIMETERS]

TOLERANCES: ANGLES ± 1°

2 PLACE DECIMALS ± 0.05 [0.127]

2 PLACE DECIMALS ± 0.01 [0.254]

REMOVE ALL BURRS AND SHARP EDGES

CONCENTRICITY-MACHINED CHAMFERS-30-PM

DIMENSIONAL LIMITS APPLY BEFORE FINISHES

PARENTHEetical INFO FOR REF ONLY

HOLE TOLERANCE

1/16 ± .004 1/8 ± .005 3/16 ± .006 1/4 ± .007 5/16 ± .008 3/4 ± .009 1 ± .010 1 1/4 ± .011 2 ± .012 2 1/2 ± .013 3 ± .014 4 ± .015 5 ± .016 6 ± .017 8 ± .018 10 ± .019 12 ± .020 14 ± .021 16 ± .022 18 ± .023 20 ± .024 22 ± .025 24 ± .026 26 ± .027 28 ± .028 30 ± .029 32 ± .030 34 ± .031 36 ± .032 38 ± .033 40 ± .034 42 ± .035 44 ± .036 46 ± .037 48 ± .038 50 ± .039 52 ± .040 54 ± .041 56 ± .042 58 ± .043 60 ± .044 62 ± .045 64 ± .046 66 ± .047 68 ± .048 70 ± .049 72 ± .050 74 ± .051 76 ± .052 78 ± .053 80 ± .054 82 ± .055 84 ± .056 86 ± .057 88 ± .058 90 ± .059 92 ± .060 94 ± .061 96 ± .062 98 ± .063 100 ± .064 102 ± .065 104 ± .066 106 ± .067 108 ± .068 110 ± .069 112 ± .070 114 ± .071 116 ± .072 118 ± .073 120 ± .074 122 ± .075 124 ± .076 126 ± .077 128 ± .078 130 ± .079 132 ± .080 134 ± .081 136 ± .082 138 ± .083 140 ± .084 142 ± .085 144 ± .086 146 ± .087 148 ± .088 150 ± .089 152 ± .090 154 ± .091 156 ± .092 158 ± .093 160 ± .094 162 ± .095 164 ± .096 166 ± .097 168 ± .098 170 ± .099 172 ± .100 174 ± .101 176 ± .102 178 ± .103 180 ± .104 182 ± .105 184 ± .106 186 ± .107 188 ± .108 190 ± .109 192 ± .110 194 ± .111 196 ± .112 198 ± .113 200 ± .114 202 ± .115 204 ± .116 206 ± .117 208 ± .118 210 ± .119 212 ± .120 214 ± .121 216 ± .122 218 ± .123 220 ± .124 222 ± .125 224 ± .126 226 ± .127 228 ± .128 230 ± .129 232 ± .130 234 ± .131 236 ± .132 238 ± .133 240 ± .134 242 ± .135 244 ± .136 246 ± .137 248 ± .138 250 ± .139 252 ± .140 254 ± .141 256 ± .142 258 ± .143 260 ± .144 262 ± .145 264 ± .146 266 ± .147 268 ± .148 270 ± .149 272 ± .150 274 ± .151 276 ± .152 278 ± .153 280 ± .154 282 ± .155 284 ± .156 286 ± .157 288 ± .158 290 ± .159 292 ± .160 294 ± .161 296 ± .162 298 ± .163 300 ± .164 302 ± .165 304 ± .166 306 ± .167 308 ± .168 310 ± .169 312 ± .170 314 ± .171 316 ± .172 318 ± .173 320 ± .174 322 ± .175 324 ± .176 326 ± .177 328 ± .178 330 ± .179 332 ± .180 334 ± .181 336 ± .182 338 ± .183 340 ± .184 342 ± .185 344 ± .186 346 ± .187 348 ± .188 350 ± .189 352 ± .190 354 ± .191 356 ± .192 358 ± .193 360 ± .194 362 ± .195 364 ± .196 366 ± .197 368 ± .198 370 ± .199 372 ± .200 374 ± .201 376 ± .202 378 ± .203 380 ± .204 382 ± .205 384 ± .206 386 ± .207 388 ± .208 390 ± .209 392 ± .210 394 ± .211 396 ± .212 398 ± .213 400 ± .214 402 ± .215 404 ± .216 406 ± .217 408 ± .218 410 ± .219 412 ± .220 414 ± .221 416 ± .222 418 ± .223 420 ± .224 422 ± .225 424 ± .226 426 ± .227 428 ± .228 430 ± .229 432 ± .230 434 ± .231 436 ± .232 438 ± .233 440 ± .234 442 ± .235 444 ± .236 446 ± .237 448 ± .238 450 ± .239 452 ± .240 454 ± .241 456 ± .242 458 ± .243 460 ± .244 462 ± .245 464 ± .246 466 ± .247 468 ± .248 470 ± .249 472 ± .250 474 ± .251 476 ± .252 478 ± .253 480 ± .254 482 ± .255 484 ± .256 486 ± .257 488 ± .258 490 ± .259 492 ± .260 494 ± .261 496 ± .262 498 ± .263 500 ± .264 502 ± .265 504 ± .266 506 ± .267 508 ± .268 510 ± .269 512 ± .270 514 ± .271 516 ± .272 518 ± .273 520 ± .274 522 ± .275 524 ± .276 526 ± .277 528 ± .278 530 ± .279 532 ± .280 534 ± .281 536 ± .282 538 ± .283 540 ± .284 542 ± .285 544 ± .286 546 ± .287 548 ± .288 550 ± .289 552 ± .290 554 ± .291 556 ± .292 558 ± .293 560 ± .294 562 ± .295 564 ± .296 566 ± .297 568 ± .298 570 ± .299 572 ± .300 574 ± .301 576 ± .302 578 ± .303 580 ± .304 582 ± .305 584 ± .306 586 ± .307 588 ± .308 590 ± .309 592 ± .310 594 ± .311 596 ± .312 598 ± .313 600 ± .314 602 ± .315 604 ± .316 606 ± .317 608 ± .318 610 ± .319 612 ± .320 614 ± .321 616 ± .322 618 ± .323 620 ± .324 622 ± .325 624 ± .326 626 ± .327 628 ± .328 630 ± .329 632 ± .330 634 ± .331 636 ± .332 638 ± .333 640 ± .334 642 ± .335 644 ± .336 646 ± .337 648 ± .338 650 ± .339 652 ± .340 654 ± .341 656 ± .342 658 ± .343 660 ± .344 662 ± .345 664 ± .346 666 ± .347 668 ± .348 670 ± .349 672 ± .350 674 ± .351 676 ± .352 678 ± .353 680 ± .354 682 ± .355 684 ± .356 686 ± .357 688 ± .358 690 ± .359 692 ± .360 694 ± .361 696 ± .362 698 ± .363 700 ± .364 702 ± .365 704 ± .366 706 ± .367 708 ± .368 710 ± .369 712 ± .370 714 ± .371 716 ± .372 718 ± .373 720 ± .374 722 ± .375 724 ± .376 726 ± .377 728 ± .378 730 ± .379 732 ± .380 734 ± .381 736 ± .382 738 ± .383 740 ± .384 742 ± .385 744 ± .386 746 ± .387 748 ± .388 750 ± .389 752 ± .390 754 ± .391 756 ± .392 758 ± .393 760 ± .394 762 ± .395 764 ± .396 766 ± .397 768 ± .398 770 ± .399 772 ± .400 774 ± .401 776 ± .402 778 ± .403 780 ± .404 782 ± .405 784 ± .406 786 ± .407 788 ± .408 790 ± .409 792 ± .410 794 ± .411 796 ± .412 798 ± .413 800 ± .414 802 ± .415 804 ± .416 806 ± .417 808 ± .418 810 ± .419 812 ± .420 814 ± .421 816 ± .422 818 ± .423 820 ± .424 822 ± .425 824 ± .426 826 ± .427 828 ± .428 830 ± .429 832 ± .430 834 ± .431 836 ± .432 838 ± .433 840 ± .434 842 ± .435 844 ± .436 846 ± .437 848 ± .438 850 ± .439 852 ± .440 854 ± .441 856 ± .442 858 ± .443 860 ± .444 862 ± .445 864 ± .446 866 ± .447 868 ± .448 870 ± .449 872 ± .450 874 ± .451 876 ± .452 878 ± .453 880 ± .454 882 ± .455 884 ± .456 886 ± .457 888 ± .458 890 ± .459 892 ± .460 894 ± .461 896 ± .462 898 ± .463 900 ± .464 902 ± .465 904 ± .466 906 ± .467 908 ± .468 910 ± .469 912 ± .470 914 ± .471 916 ± .472 918 ± .473 920 ± .474 922 ± .475 924 ± .476 926 ± .477 928 ± .478 930 ± .479 932 ± .480 934 ± .481 936 ± .482 938 ± .483 940 ± .484 942 ± .485 944 ± .486 946 ± .487 948 ± .488 950 ± .489 952 ± .490 954 ± .491 956 ± .492 958 ± .493 960 ± .494 962 ± .495 964 ± .496 966 ± .497 968 ± .498 970 ± .499 972 ± .500 974 ± .501 976 ± .502 978 ± .503 980 ± .504 982 ± .505 984 ± .506 986 ± .507 988 ± .508 990 ± .509 992 ± .510 994 ± .511 996 ± .512 998 ± .513 1000 ± .514 1002 ± .515 1004 ± .516 1006 ± .517 1008 ± .518 1010 ± .519 1012 ± .520 1014 ± .521 1016 ± .522 1018 ± .523 1020 ± .524 1022 ± .525 1024 ± .526 1026 ± .527 1028 ± .528 1030 ± .529 1032 ± .530 1034 ± .531 1036 ± .532 1038 ± .533 1040 ± .534 1042 ± .535 1044 ± .536 1046 ± .537 1048 ± .538 1050 ± .539 1052 ± .540 1054 ± .541 1056 ± .542 1058 ± .543 1060 ± .544 1062 ± .545 1064 ± .546 1066 ± .547 1068 ± .548 1070 ± .549 1072 ± .550 1074 ± .551 1076 ± .552 1078 ± .553 1080 ± .554 1082 ± .555 1084 ± .556 1086 ± .557 1088 ± .558 1090 ± .559 1092 ± .560 1094 ± .561 1096 ± .562 1098 ± .563 1100 ± .564 1102 ± .565 1104 ± .566 1106 ± .567 1108 ± .568 1110 ± .569 1112 ± .570 1114 ± .571 1116 ± .572 1118 ± .573 1120 ± .574 1122 ± .575 1124 ± .576 1126 ± .577 1128 ± .578 1130 ± .579 1132 ± .580 1134 ± .581 1136 ± .582 1138 ± .583 1140 ± .584 1142 ± .585 1144 ± .586 1146 ± .587 1148 ± .588 1150 ± .589 1152 ± .590 1154 ± .591 1156 ± .592 1158 ± .593 1160 ± .594 1162 ± .595 1164 ± .596 1166 ± .597 1168 ± .598 1170 ± .599 1172 ± .600 1174 ± .601 1176 ± .602 1178 ± .603 1180 ± .604 1182 ± .605 1184 ± .606 1186 ± .607 1188 ± .608 1190 ± .609 1192 ± .610 1194 ± .611 1196 ± .612 1198 ± .613 1200 ± .614 1202 ± .615 1204 ± .616 1206 ± .617 1208 ± .618 1210 ± .619 1212 ± .620 1214 ± .621 1216 ± .622 1218 ± .623 1220 ± .624 1222 ± .625 1224 ± .626 1226 ± .627 1228 ± .628 1230 ± .629 1232 ± .630 1234 ± .631 1236 ± .632 1238 ± .633 1240 ± .634 1242 ± .635 1244 ± .636 1246 ± .637 1248 ± .638 1250 ± .639 1252 ± .640 1254 ± .641 1256 ± .642 1258 ± .643 1260 ± .644 1262 ± .645 1264 ± .646 1266 ± .647 1268 ± .648 1270 ± .649 1272 ± .650 1274 ± .651 1276 ± .652 1278 ± .653 1280 ± .654 1282 ± .655 1284 ± .656 1286 ± .657 1288 ± .658 1290 ± .659 1292 ± .660 1294 ± .661 1296 ± .662 1298 ± .663 1300 ± .664 1302 ± .665 1304 ± .666 1306 ± .667 1308 ± .668 1310 ± .669 1312 ± .670 1314 ± .671 1316 ± .672 1318 ± .673 1320 ± .674 1322 ± .675 1324 ± .676 1326 ± .677 1328 ± .678 1330 ± .679 1332 ± .680 1334 ± .681 1336 ± .682 1338 ± .683 1340 ± .684 1342 ± .685 1344 ± .686 1346 ± .687 1348 ± .688 1350 ± .689 1352 ± .690 1354 ± .691 1356 ± .692 1358 ± .693 1360 ± .694 1362 ± .695 1364 ± .696 1366 ± .697 1368 ± .698 1370 ± .699 1372 ± .700 1374 ± .701 1376 ± .702 1378 ± .703 1380 ± .704 1382 ± .705 1384 ± .706 1386 ± .707 1388 ± .708 1390 ± .709 1392 ± .710 1394 ± .711 1396 ± .712 1398 ± .713 1400 ± .714 1402 ± .715 1404 ± .716 1406 ± .717 1408 ± .718 1410 ± .719 1412 ± .720 1414 ± .721 1416 ± .722 1418 ± .723 1420 ± .724 1422 ± .725 1424 ± .726 1426 ± .727 1428 ± .728 1430 ± .729 1432 ± .730 1434 ± .731 1436 ± .732 1438 ± .733 1440 ± .734 1442 ± .735 1444 ± .736 1446 ± .737 1448 ± .738 1450 ± .739 1452 ± .740 1454 ± .741 1456 ± .742 1458 ± .743 1460 ± .744 1462 ± .745 1464 ± .746 1466 ± .747 1468 ± .748 1470 ± .749 1472 ± .750 1474 ± .751 1476 ± .752 1478 ± .753 1480 ± .754 1482 ± .755 1484 ± .756 1486 ± .757 1488 ± .758 1490 ± .759 1492 ± .760 1494 ± .761 1496 ± .762 1498 ± .763 1500 ± .764 1502 ± .765 1504 ± .766 1506 ± .767 1508 ± .768 1510 ± .769 1512 ± .770 1514 ± .771 1516 ± .772 1518 ± .773 1520 ± .774 1522 ± .775 1524 ± .776 1526 ± .777 1528 ± .778 1530 ± .779 1532 ± .780 1534 ± .781 1536 ± .782 1538 ± .783 1540 ± .784 1542 ± .785 1544 ± .786 1546 ± .787 1548 ± .788 1550 ± .789 1552 ± .790 1554 ± .791 1556 ± .792 1558 ± .793 1560 ± .794 1562 ± .795 1564 ± .796 1566 ± .797 1568 ± .798 1570 ± .799 1572 ± .800 1574 ± .801 1576 ± .802 1578 ± .803 1580 ± .804 1582 ± .805 1584 ± .806 1586 ± .807 1588 ± .808 1590 ± .809 1592 ± .810 1594 ± .811 1596 ± .812 1598 ± .813 1600 ± .814 1602 ± .815 1604 ± .816 1606 ± .817 1608 ± .818 1610 ± .819 1612 ± .820 1614 ± .821 1616 ± .822 1618 ± .823 1620 ± .824 1622 ± .825 1624 ± .826 1626 ± .827 1628 ± .828 1630 ± .829 1632 ± .830 1634 ± .831 1636 ± .832 1638 ± .833 1640 ± .834 1642 ± .835 1644 ± .836 1646 ± .837 1648 ± .838 1650 ± .839 1652 ± .840 1654 ± .841 1656 ± .842 1658 ± .843 1660 ± .844 1662 ± .845 1664 ± .846 1666 ± .847 1668 ± .848 1670 ± .849 1672 ± .850 1674 ± .851 1676 ± .852 1678 ± .853 1680 ± .854 1682 ± .855 1684 ± .856 1686 ± .857 1688 ± .858 1690 ± .859 1692 ± .860 1694 ± .861 1696 ± .862 1698 ± .863 1700 ± .864 1702 ± .865 1704 ± .866 1706 ± .867 1708 ± .868 1710 ± .869 1712 ± .870 1714 ± .871 1716 ± .872 1718 ± .873 1720 ± .874 1722 ± .875 1724 ± .876 1726 ± .877 1728 ± .878 1730 ± .879 1732 ± .880 1734 ± .881 1736 ± .882 1738 ± .883 1740 ± .884 1742 ± .885 1744 ± .886 1746 ± .887 1748 ± .888 1750 ± .889 1752 ± .890 1754 ± .891 1756 ± .892 1758 ± .893 1760 ± .894 1762 ± .895 1764 ± .896 1766 ± .897 1768 ± .898 1770 ± .899 1772 ± .900 1774 ± .901 1776 ± .902 1778 ± .903 1780 ± .904 1782 ± .905 1784 ± .906 1786 ± .907 1788 ± .908 1790 ± .909 1792 ± .910 1794 ± .911 1796 ± .912 1798 ± .913 1800 ± .914 1802 ± .915 1804 ± .916 1806 ± .917 1808 ± .918 1810 ± .919 1812 ± .920 1814 ± .921 1816 ± .922 1818 ± .923 1820 ± .924 1822 ± .925 1824 ± .926 1826 ± .927 1828 ± .928 1830 ± .929 1832 ± .930 1834 ± .931 1836 ± .932 1838 ± .933 1840 ± .934 1842 ± .935 1844 ± .936 1846 ± .937 1848 ± .938 1850 ± .939 1852 ± .940 1854 ± .941 1856 ± .942 1858 ± .943 1860 ± .944 1862 ± .945 1864 ± .946 1866 ± .947 1868 ± .948 1870 ± .949 1872 ± .950 1874 ± .951 1876 ± .952 1878 ± .953 1880 ± .954 1882 ± .955 1884 ± .956 1886 ± .957 1888 ± .958 1890 ± .959 1892 ± .960 1894 ± .961 1896 ± .962 1898 ± .963 1900 ± .964 1902 ± .965 1904 ± .966 1906 ± .967 1908 ± .968 1910 ± .969 1912 ± .970 1914 ± .971 1916 ± .972 1918 ± .973 1920 ± .974 1922 ± .975 1924 ± .976 1926 ± .977 1928 ± .978 1930 ± .979 1932 ± .980 1934 ± .981 1936 ± .982 1938 ± .983 1940 ± .984 1942 ± .985 1944 ± .986 1946 ± .987 1948 ± .988 1950 ± .989 1952 ± .990 1954 ± .991 1956 ± .992 1958 ± .993 1960 ± .994 1962 ± .995 1964 ± .996 1966 ± .997 1968 ± .998 1970 ± .999 1972 ± .1000 1974 ± .1001 1976 ± .1002 1978 ± .1003 1980 ± .1004 1982 ± .1005 1984 ± .1006 1986 ± .1007 1988 ± .1008 1990 ± .1009 1992 ± .1010 1994 ± .1011 1996 ± .1012 1998 ± .1013 2000 ± .1014 2002 ± .1015 2004 ± .1016 2006 ± .1017 2008 ± .1018 2010 ± .1019 2012 ± .1020 2014 ± .1021 2016 ± .1022 2018 ± .1023 2020 ± .1024 2022 ± .1025 2024 ± .1026 2026 ± .1027 2028 ± .1028 2030 ± .1029 2032 ± .1030 2034 ± .1031 2036 ± .1032 2038 ± .1033 2040 ± .1034 2042 ± .1035 2044 ± .1036 2046 ± .1037 2048 ± .1038 2050 ± .1039 2052 ± .1040 2054 ± .1041 2056 ± .1042 2058 ± .1043 2060 ± .1044 2062 ± .1045 2064 ± .1046 2066 ± .1047 2068 ± .1048 2070 ± .1049 2072 ± .1050 2074 ± .1051 2076 ± .1052 2078 ± .1053 2080 ± .1054 2082 ± .1055 2084 ± .1056 2086 ± .1057 2088 ± .1058 2090 ± .1059 2092 ± .1060 2094 ± .1061 2096 ± .1062 2098 ± .1063 2100 ± .1064 2102 ± .1065 2104 ± .1066 2106 ± .1067 2108 ± .1068 2110 ± .1069 2112 ± .1070 2114 ± .1071 2116 ± .1072 2118 ± .1073 2120 ± .1074 2122 ± .







D

C

B

A

D

C

2507867

A

4

3

2

1

4

3

2

1

203X  $\varnothing.054 \pm .003$  [1.3716  $\pm$  0.0762]

$\varnothing.020$	[0.508]	D	B	C
$\varnothing.010$	[0.254]	D		

29X .050 [1.27] = 1.450 [36.83]

.075 [1.905]

(.100 [2.54])

(.050 [1.27])

.075 [1.905]

.365  $\pm$  .010 [9.271  $\pm$  0.254]

[12] .52  $\pm$  .01  
[13.208  $\pm$  0.254]

(.050 [1.27])

(.100 [2.54])

22X .050 [1.27]  
= 1.100 [27.94]

SYMBOLIZATION PAD  
[10][12]

[6]  $\square$  .0004 [0.01016] / .05X.05 [1.27X1.27]

.72  $\pm$  .01 [18.288  $\pm$  0.254]

.44  $\pm$  .01 [11.176  $\pm$  0.254]

[12]

VIEW D-D (SHEET 1)  
SCALE 6/1

TEXAS INSTRUMENTS <i>College - Texas</i>	DWN	DATE	SIZE	DRAWING NO	REV
	ISSUE DATE	SCALE	3/1	2507867	B
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